

Antifriction aminopropyltriethoxysilane films on thermoplastic elastomer substrates using an APPJ system

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1 ABSTRACT

2 The study of friction coefficients has long been of great importance in the automotive
3 industry where some areas of the vehicle are subject to slippage. One example is the
4 space between the window channels and the glass. The polymeric materials that are
5 used in these areas, like thermoplastic elastomers (TPE), involve a high degree of
6 friction. So, in order to decrease the friction coefficient of the TPE, companies are using
7 such techniques as flocking. However their high energy consumption, irregular
8 distribution of fibers and poor adhesion are drawbacks. In order to overcome these
9 drawbacks, this work attempts to obtain a SiO_x-based thin film over a TPE substrate
10 using aminopropyltriethoxysilane (APTES) with similar or lower friction coefficients
11 and the same durability. Since TPE is heat-sensitive, an atmospheric-pressure plasma jet
12 system (APPJ) with a dielectric barrier discharge (DBD) was used in this study. The
13 influence of the plasma power and number of passes was characterized by Profilometry,
14 Atomic Force Microscopy (AFM), Scanning Electron Microscopy (SEM), Attenuated
15 Total Reflectance-Fourier Transform Infrared (ATR-FTIR) Spectroscopy, X-Ray
16 Photoelectron Spectroscopy (XPS), Water Contact Angle (WCA) measurements and
17 friction coefficient. The average surface temperature of the samples and the coating
18 thickness seem to be the key variables in determining the friction behavior. Successful
19 samples (those that have a lower friction coefficient than those of the current industrial
20 solutions - flocked seals and polyamide tap) were coated at an average surface
21 temperature of less than 92 °C and thicknesses of the coatings were greater than 1000
22 nm. Sample coated in six passes and the lowest power (350 W) proved to have the best
23 friction performance. This sample has a friction coefficient that is 46% lower than that
24 of the flocked seals. The results of this research permit one to conclude that a promising

1 antifriction technology using APPJ with a DBD could be an alternative to the current
2 industrial solutions.

3 **1 Introduction**

4 The study of friction coefficients and wear mechanisms has long been of great
5 importance in the operation of many mechanical systems. In fact, many industrial
6 applications require low friction coefficients. In the automotive industry, some areas of
7 the vehicles are subjected to slippage. These include the space between the window
8 channels and the glass, and between the wind-shield and the wind-shield wipers, where
9 a low friction coefficient is necessary to prevent jams. Furthermore, a high
10 hydrophobicity would be desirable in order to evacuate the stored water in the
11 operation. The polymeric materials that are used in these areas, like thermoplastic
12 elastomers (TPEs), intrinsically involve high friction [1]. So, in order to improve
13 friction performance, companies are using two different techniques, such as flocked
14 seals and a polyamide tape affixed to the tape seals. Today, the flocked method is
15 widely used in the automotive sealing industry due to its low friction coefficient. The
16 high energy consumption and long installation lines, together with an irregular
17 distribution of fibers, poor fiber orientation and poor adhesive distribution are the main
18 drawbacks of this technology [2].

19 Plasma technology is becoming more and more popular as a means to modify the
20 intrinsic properties of substrate materials by coating or activation [3–5]. Operating at
21 atmospheric pressure in a dielectric barrier discharge configuration is particularly
22 suitable for the treatment of temperature-sensitive materials, such as polymers, since it
23 generates cold plasmas [5,6].

24 The friction and wear of a material depend primarily on its surface properties [7].

25 Previous studies of plasma-polymerized siloxane coatings, like hexamethyldisiloxane

1 (HMDSO) or aminopropyltriethoxysilane (APTES), have demonstrated a reduction in
2 the friction coefficient on different substrates [8–10].
3 This paper deals with the synthesis and characterization of SiO_x-based coatings that are
4 deposited on TPE substrates that have been produced by an Atmospheric Pressure
5 Plasma Jet (APPJ) system. The main purpose is to obtain a coating that has friction
6 coefficients that are similar to, or lower than, the current industrial solutions (flocked
7 seals and polyamide tape) with the same or greater durability. It would be desirable also
8 to obtain a wettability behavior that is similar to or better than those of these industrial
9 solutions. In addition, this coating method would reduce considerably the
10 manufacturing cost, which is one of the most important concerns when developing a
11 viable coating for an industrial application [11].

12 The influence of the different process parameters, mainly plasma power and deposition
13 time (number of passes), in depositing coatings on TPE was characterized from
14 morphological, chemical and mechanical points of view by Profilometry, Atomic Force
15 Microscopy (AFM), Scanning Electron Microscopy (SEM), Attenuated Total
16 Reflectance-Fourier Transform Infrared (ATR-FTIR) spectroscopy, X-Ray
17 Photoelectron Spectroscopy (XPS), Water Contact Angle (WCA) measurements and
18 friction coefficient.

19 **2 Experimental Details**

20 **2.1 Materials and sample deposition**

21 SiO₂-based coatings of various thicknesses were deposited on flat TPE substrates of 100
22 mm x 50 mm x 2 mm that were vulcanized from pellets of SantoreneTM 121-67W175
23 (ISO 18064).

1 A schematic diagram of the atmospheric pressure plasma jet (APPJ) system of
2 PlasmaSpot[®] that was used to coat the samples is shown in [1]. This system consists of
3 an Al₂O₃ dielectric tube between two cylindrical electrodes; the outer electrode is
4 connected to high voltage during operation and the inner electrode is grounded.
5 The jet moved across the sample's surface at a scanning speed of 6 m/min and a track
6 pitch of 2 mm. The gap between the discharge plasma and the substrate was set at 6
7 mm. Nitrogen was used as the plasma gas at 80 slm. The chemical precursor, 3-
8 aminopropyltriethoxysilane (APTES), was purchased from Sigma Aldrich and used as
9 received. A fine aerosol of liquid APTES was created using an atomizer. The inlet gas
10 for the atomization was nitrogen at 1.5 slm and the size of the generated droplets ranged
11 from 10 nm to 300 nm. With the aim of preventing a direct contact of APTES fumes
12 with the plasma operator, due to its toxicity, the coating process was implemented using
13 a fume hood. The ozone generated from the air during the atmospheric pressure process
14 is evacuated with the same system. The APTES fume from the atomizer is directly
15 transported to the inner electrode via a silicone tube. At the bottom of the inner
16 electrode, the APTES fume contacts with the plasma.
17 Twelve different samples were coated as **Table 1** shows. For each sample the coating
18 process consisted of two steps, in which the same plasma power at a frequency of 68
19 kHz was used. In the first step, the sample was scanned once to activate the surface.
20 During this activation step, no precursor was introduced into the jet. Only nitrogen was
21 used as plasma gas. With the aim of studying the effect of the activation step, three
22 activated samples with different plasma power (A1/350, A1/450 and A1/550) were
23 analyzed (see **Table 1**). After activation, a process of plasma-polymerization with
24 APTES was carried out. Depending on the sample, the jet was moved across the
25 substrate surface as many times as **Table 1** indicates (number of passes).

1 In order to evaluate the effect of surface temperature on the properties of the coated
2 samples, the temperature was measured continuously during the coating process using a
3 temperature sensor that was taped to the sample's surface for the 18-pass samples
4 (S18/350, S18/450 and S18/550).

5 **2.2 Sample characterization techniques**

6 The thickness of the coatings has been evaluated by surface profilometry using a Taylor
7 Hobson Surtronic 25 profilometer, which provides data analysis and images captured by
8 scanning. The scanning length that was chosen was 4 mm and the range was 100 μm .
9 Before coating the samples, the TPE's surface was partially covered by a mask. After
10 the coating process, the mask was removed and the step's height was measured by the
11 mechanical profilometer. The average coating thickness of five measurements from
12 each sample was determined.

13 An XE-70 Atomic Force Microscopy system (AFM) (Park systems) was used to explore
14 the surface topography and the roughness of the samples. Areas of 40 μm x 40 μm were
15 scanned in non-contact mode with a silicon cantilever (NanosensorsTM PPP-NCHR).

16 Data processing was done by applying a plane fit algorithm. The root mean square
17 (RMS) roughness was calculated as the average value of the measurements of three
18 different spots per sample by means of NanoScope Analysis 1.4 software.

19 The surface morphology of all the samples was examined by use of a Scanning Electron
20 Microscope (SEM) HITACHI S-2400 at an operating voltage of 18 kV. Samples that
21 were analyzed were made conductive by gold-palladium sputtering before introduction
22 to the SEM chamber to prevent charging during SEM analysis. An energy dispersive X-
23 ray spectroscopy (EDX) that was installed in the SEM was used to study the atomic
24 chemical composition of the uppermost layer of the coatings and the wear tracks.

1 Attenuated Total Reflectance-Fourier Transform Infrared (ATR- FTIR) spectroscopy
2 spectra were recorded on a Bruker Tensor 27 spectrometer that was equipped with a
3 single reflection ATR accessory for chemical bond characterization of the samples. For
4 each spectrum, 32 scans were collected and averaged in the range of 600-4000 cm^{-1} at a
5 4 cm^{-1} resolution.

6 The atomic chemical surface composition of the samples was monitored using a
7 Physical Electronics PHI 5700 spectrometer with a multi-channel hemispherical
8 analyzer, a pass energy of 29.35 eV and $\text{MgK}\alpha$ (1253.6 eV) X-radiation (XPS). XPS
9 deconvolutions were undertaken with the PeakFit 4.12 (SPSS Inc.) software by fitting
10 each spectrum with a mixture of Gaussian-Lorentzian functions. A 285 eV binding
11 energy related to the C1s signal was used to calibrate the energy scale for XPS
12 deconvolutions.

13 To determine the wettability of the samples, the static water contact angles (WCA) were
14 measured by the sessile drop method. The WCA value of each sample was calculated as
15 an average of four measurements (10 μL /drop) by image analysis.

16 In order to study the tribological performance of the analyzed samples, tribological tests
17 were conducted with a CSM tribometer using the ball-on-disk method. This method
18 consists of a 100 Cr6 steel ball (60-62 HRC, 6 mm in diameter) that is in contact with
19 the surface of the sample with an applied load. The sample is spun and the steel ball
20 makes a circular groove in the sample. The test parameters that were established were a
21 sliding speed of 2 cm/s, a radius of 2.5 mm, a normal load of 1N and a test length of
22 4000 m.

23 **2.3 Surface temperature of the coatings**

1 **Fig. 1** shows the average surface temperature as a function of the number of passes.
2 During the deposition process, the ambient air temperature was maintained constantly at
3 21°C. The sample holder was not equipped with a heating or cooling instrument.
4 **Fig. 1** shows clearly that the average surface temperature rises slowly with the number
5 of passes for a given power (350, 450 or 550 W). This increase is due to the energy
6 stored in the plasma and the coating during the deposition process [12]. The longer the
7 deposition process is, the higher is the surface temperature that is reached. For a
8 selected number of passes, an increase in the average temperature is observed when the
9 power of the plasma polymerization process is raised. That is, the surface temperature is
10 strongly dependent on the power [13]. A higher power results in more energetic ions,
11 molecules and particulates [14–16], which may cause plasma etching of the coating
12 surface. As some studies have discovered [17–20], the surface temperature of the
13 samples and its residence time can have a great impact on chemical composition and
14 structure, surface morphology and mechanical performance of the as-deposited samples,
15 especially when temperature-sensitive substrates, such as TPE, are used [21]. This is the
16 reason why the following sections contain a detailed study of morphology, chemical
17 composition and friction behavior.

18 **3 Results and Discussion**

19 **3.1 Coating thickness**

20 3.1.1 Effect of the number of passes

21 **Fig. 2 [a]** and **Table 2** show the thickness and standard deviation of the deposited
22 coatings. **Fig. 2 [a]** shows that, for a specific power, the coating thickness increases in
23 linear fashion with the number of passes. That is, the thickness of the coating is a
24 function of the deposition time. The reason is that the plasma jet is working longer,

1 since it passes over the sample's surface more times. This causes further growth of the
2 coatings with a consequent increase in thickness.

3 The growth rate of each sample was obtained by dividing its film thickness by the
4 number of passes. As shown in **Fig. 2[b]**, it was discovered that the curve of the growth
5 rate for a specified power reaches a maximum at about six passes followed by a linear
6 decrement for up to eighteen passes [22,23]. This behavior seems to be related to the
7 roughness of the samples, since the curve of the roughness (**Fig. 3**) shows an inverse
8 shape to that of growth rate. In this respect, when the 2-pass samples are coated, the
9 surface exposed to plasma-polymerization appears to be largely determined by the
10 roughness of the uncoated TPE sample. During this process, the cavities of the uncoated
11 TPE are being filled and as the number of passes increases (from 2 to 6 passes), the
12 sample becomes increasingly smooth. This decrease in roughness causes the area
13 exposed to plasma-polymerization to be lower, resulting in a higher growth rate. When
14 reaching 6 passes, the roughness values for these samples are the lowest and therefore
15 the area exposed to the plasma-polymerization are the lowest. Given that the precursor
16 flow rate is constant (1.5 slm) throughout the deposition process, a decrease of the area
17 exposed to the plasma-polymerization involves an increase of the growth rate. As the
18 number of passes increases (from 6 to 18 passes), the roughness increases due to the
19 growth of the particles. This causes an increase of the area exposed to the plasma-
20 polymerization which in turn results in a decrease in growth rate.

21 3.1.2 Effect of the plasma power

22 In **Fig. 2**, neither the thickness nor the growth rate of the coatings changed significantly
23 with plasma power. In **Table 2**, one can see the high standard deviations (SD), which
24 exceed 25 percent of the coating's thickness in many cases. This is explained by the

1 growing mechanisms and the morphology of the coatings over the TPE substrate, as is
2 mentioned below.

3 **3.2 Surface morphology**

4 3.2.1 Effect of the number of passes

5 **Fig. 3** depicts the average roughness of all the samples. In this figure, one can see that,
6 for a given power, the roughness increases as the number of passes increases.

7 It is noteworthy that, for a specified power, the roughness of samples that were coated
8 in two passes (S2/350, S2/450 and S2/550) is slightly higher than the roughness of
9 samples that were coated in six passes (S6/350, S6/450 and S6/550). However, the
10 surface of 2-pass samples probably has not been completely coated, since such coatings
11 are very thin (S2/350: 230 nm, S2/450: 190 nm and S2/550: 160 nm) in comparison to
12 TPE's roughness (RMS: 364 nm) and its own roughness (S2/350: 401 nm, S2/450: 276
13 nm and S2/550: 376 nm). The reliability of the thickness measurements for 2-pass
14 samples is questionable since it was difficult to identify if the profilometry
15 measurements correspond to the thickness of the coating or to a discontinuity of the raw
16 substrate. Nevertheless, the use of six passes to coat samples is sufficient to fully cover
17 the TPE's surface. This provides smoother coatings (S6/350: 338 nm, S6/450: 257 nm
18 and S6/550: 322 nm) with thicknesses greater than 1000 nm (S6/350: 1524 nm, S6/450:
19 1483 nm and S6/550: 1402 nm).

20 **Fig. 4** illustrates tilted SEM images, whereas **Fig. 5** shows AFM images of samples
21 S2/350, S6/350, S6/550, S18/350, S18/550 and the uncoated TPE. **Fig. 6** shows SEM
22 images with cracks of samples coated with 350 W and 550 W. SEM and AFM images
23 of the uncoated TPE substrate (**Fig. 4[d]** and **Fig. 5[d]**) exhibit a highly fibrous aspect
24 and some carbon particles of TPE substrate. Samples that are coated at 350 W (see **Fig.**

1 **4[b-c]** and **Fig. 5[b-c]**) exhibit a coating that consists of spherical particles that have
2 been deposited on the TPE fibers. It would appear that the morphology of APTES
3 coatings relies heavily on the uncoated TPE's morphology.

4 In fact, it is believed that both the fibers and carbon particles of TPE substrate probably
5 act as nucleation sites where the coating grows [24]. This agrees with the SEM and
6 AFM images of sample S6/350 (see **Fig. 4[b]**, **Fig. 5[b]** and **Fig. 6[a]**) that show some
7 spherical particles that have been deposited on both nucleation sites. An increase in the
8 number of passes results in gas species remaining longer in the plasma jet. This favors
9 precursor fragmentation and recombination of different particles during the plasma-
10 polymerization process [25]. In turn, this causes an increase in size and number of
11 spherical particulates as **Fig. 4[c]**, **Fig.5[c]** and **Fig. 6[c]** illustrate. Such spherical
12 growth is also promoted by the so-called shadowing effect, which is caused by
13 geometric interaction between the surface roughness of the growing film and the
14 angular direction of the arriving coating species. That is, the deposition rate at the top of
15 spherical particles is higher than at the bottom of the voids where the incident angle for
16 arriving coating species is thinner. [22,24]. As a result of this growth mechanism, there
17 is an increase in roughness (S6/350: 338 nm → S18/350: 724 nm) and thickness of the
18 coatings (S6/350:1524 nm → S18/350: 2938 nm).

19 Cracking has been observed clearly on the surface of these samples under SEM analysis
20 (as **Fig. 6**). The residual thermal stress that is due to differences between the
21 thermomechanical properties of the coating and the TPE substrate [21,26,27], and the
22 coating embrittlement by the higher number of passes may be two of the main causes
23 of cracking [4]. It should be noted that the size of the cracks is the greatest in the
24 samples that were coated in the greatest number of passes. This can be related to the

1 cumulative effect of the surface temperature due to the longer exposure of the sample to
2 an energetic plasma, as can be seen in **Fig. 1** [28,29].

3 3.2.2 Effect of the plasma power

4 **Fig. 7** illustrates SEM images of the uncoated TPE together with the samples activated
5 with 350 W and 550 W. In these images, one can observe that the activation process
6 cause a slight etching of the substrate. Moreover, the roughness of the activated samples
7 are slightly higher than the roughness of the uncoated TPE (see **Table 2**).

8 Related to the coated samples, the higher the plasma power (350 W→550 W) is, the
9 greater is the precursor decomposition during the gas phase reactions of the plasma and
10 the higher is the number of small particulates on the coating surface [1]. In fact, one can
11 compare the size and number of particulates of samples that have been coated in six
12 passes (**Fig. 4[b]-[e]**, **Fig. 5[b]-[e]** and **Fig. 6[a]-[d]**), and note a higher number of
13 smaller particles on samples that have been coated at higher plasma power.

14 The same applies to 18-pass samples (**Fig. 4[c]-[f]**, **Fig. 5[c]-[f]** and **Fig. 6[c]-[f]**),
15 which result in a decrease in roughness with increasing power (S18/350: 724 nm and
16 S18/550: 629 nm), since spherical particles create a denser and more compact coating
17 that fits the uncoated TPE's morphology better [18,30]. The more energetic ions,
18 molecules and particles that are achieved with higher plasma powers cause an increase
19 in the average surface temperature of the samples (see **Fig. 1**).

20 The ions that bombard the sample surface are needed to ensure smooth and dense
21 coatings. However, in certain cases, they may become too powerful and cause an
22 increase in the temperature of the sample. This increase, if followed by cooling of the
23 sample after the coating process, generates residual thermal stress. The impact of
24 residual thermal stress will be discussed in Section 3.5 *Tribological tests*.

1 **Fig. 8** shows the AFM profiles of sample S6/350 and samples that were coated in
2 eighteen passes (S18/350, S18/450 and S18/550). All of the studied profiles were
3 obtained following the TPE's fibers direction that, it is believed, act as nucleation sites.
4 By comparing samples that were coated with the same power (S6/350 and S18/350)
5 (**Fig. 8[a] and [b]**), one can confirm the aforementioned increase in both the diameter
6 and the number of particles with a higher number of passes.

7 In regard to the samples that were coated with the same number of passes and different
8 powers (**Fig. 8[b-d]**), the profile of sample S18/350 evinces a small number of spherical
9 particles with large diameters ($\sim 5 \mu\text{m}$). The greater the power is, the smaller is the
10 diameter, and the higher is the number of particles. In this way, sample S18/450 exhibits
11 an average diameter of $\sim 3 \mu\text{m}$ and sample S18/550 shows an average diameter of ~ 1.5
12 μm with many particles.

13 Regarding the crack formation, one can observe in **Fig. 6** that the higher the power is,
14 the greatest the number of cracks is. This is probably due to the temperature effect,
15 which is similar to what happens with the increment of the number of passes.

16 Considering the aforementioned, one can conclude that the SEM results are in good
17 agreement with the AFM images and confirm that the surface roughness was affected
18 significantly by the deposition conditions. In this regard, **Fig. 9** illustrates a scheme of
19 the growth mechanisms of coating by the plasma power and number of passes. In **Fig.**
20 **9**, one can see the strong influence of the substrate's morphology during the early
21 growth stages. As the number of passes increases, the fibrous aspect of the substrate is
22 replaced progressively by a coating that consists of spherical particles from the gas
23 phase reactions. The number and size of the particles depend on the plasma power.

24 Once cavities and holes in the TPE substrate have been covered fully (samples S6/350
25 and S6/550), the coating's morphology depends, essentially, on the number and size of

1 the spherical particles that have been generated and deposited. This explains the
2 morphology of samples that have been coated in eighteen passes.

3 **3.3 ATR-FTIR analysis**

4 ATR-FTIR spectroscopy was used to examine the chemical characteristics of all the
5 analyzed samples. **Fig. 10** shows the spectra of the uncoated TPE together and the
6 activated samples (A1/350, A1/450 and A1/550). **Fig. 11** and **Fig. 12** depict the ATR-
7 FTIR spectra of samples that were coated at 350 W (S6/350, S12/350 and S18/350) and
8 in six passes (S6/350, S6/450 and S6/550) respectively in the 0-4000 cm^{-1} range.
9 Chemical bonds that are shown in these figures correspond only to the chemical
10 composition of the coatings. Chemical bonds that correspond to the uncoated TPE
11 substrate are not shown in these figures since the thickness of these coatings exceeds the
12 depth of analysis of this technique (<1000 nm). **Fig. 13** shows the ATR-FTIR spectrum
13 of the uncoated TPE sample and samples S2/350 and S2/550. Considering that the
14 thickness of 2-pass samples is less than 1000 nm (see **Table 2**), the contribution of the
15 uncoated TPE signal was subtracted from their absorption spectrums.

16 The main peaks of the uncoated TPE spectrum were described in an earlier work by
17 these authors [10]. As shown in **Fig. 10**, the same peaks that are observed in the
18 characteristic spectrum of the uncoated TPE are also identified in the activated samples.
19 However, the activated samples exhibit a new wide band that is located in the range
20 $\sim 1600\text{-}1700$ cm^{-1} corresponding to C=O and C=C bonds [31]. The spectra of the coated
21 samples contain peaks at ~ 720 and ~ 805 cm^{-1} that are related to $-\text{CH}_2$ rocking and Si-
22 C/SiOSi bending vibration functional groups, respectively [14,29,30]. In the range 840-
23 1250 cm^{-1} , a broad band can be seen that corresponds to six different overlapping
24 functional groups: methyl rocking mode at ~ 950 cm^{-1} [4], a stretching vibration of

1 SiOSi at $\sim 1050\text{ cm}^{-1}$ [10], the SiOC ring link at $\sim 1074\text{ cm}^{-1}$ [10], the SiOC open link
2 at $\sim 1115\text{ cm}^{-1}$ [10,32], the SiOC cage link at $\sim 1172\text{ cm}^{-1}$ [10,32], and OCH₂CH₃ at
3 $\sim 1200\text{ cm}^{-1}$ [10,33]. Different peaks can be identified in the range of $\sim 1250\text{-}1500\text{ cm}^{-1}$,
4 which account for the stretching mode of Si-(CH₃)_x, C-N, C=O, and C-C groups
5 [14,29,34]. The band in the region of $\sim 1500\text{-}1700\text{ cm}^{-1}$ is attributed to amine and amide
6 functional groups [10,34]. The band in the region $\sim 2800\text{-}2950\text{ cm}^{-1}$ is related to CH_x
7 stretching modes [4,34]. Finally, the broad band in the $3000\text{-}3600\text{ cm}^{-1}$ range can be
8 attributed to various functional groups: -OH from SiOH and/or absorbed H₂O and NH_x
9 stretching [17,18,29].

10 3.3.1 Effect of the number of passes

11 It is evident in a comparison of the peak intensity of the spectrum of the samples that
12 were coated at 350 W, as **Fig. 11** shows, that the lower the number of passes is, the
13 higher the ATR-FTIR spectrum intensity is. This trend is probably explained by the
14 coating morphology. In Section 3.2 *Surface morphology*, it was seen that a higher
15 number of passes resulted in an increase in the number and size of spherical particles of
16 the coating (see **Fig. 4** and **Fig. 5**) leading to a greater roughness. So, as **Fig. 8[a] and**
17 **[b]** illustrate, sample S18/350 (RMS: 724 nm) exhibits a voided profile with higher
18 roughness than sample S6/350 (RMS: 338 nm). Bearing in mind that the analysis depth
19 of the ATR-FTIR technique is less than 1000 nm together with the thickness of these
20 two samples (greater than 1000 nm), the intensity signal of the functional groups of
21 sample S18/350 would be penalized due to the existence of an air gap between the
22 diamond ATR element and the sample surface. This results in a spectrum with lower
23 intensities that is not representative of the nature of this coating [35–38].

24 3.3.2 Effect of the plasma power

1 For the activated samples, the higher is the plasma power, the lower is the absorbance
2 areas of peaks located at ~ 1100 (C-O) and $\sim 2800-2950$ (CH_x) cm^{-1} and the higher is the
3 absorbance areas of the bands in the range $\sim 1600-1700$ (C=O and C=C) and $\sim 3000-$
4 3600 (OH) cm^{-1} (see **Fig. 10**). It seems that an increase in plasma power causes the
5 breakage of low energy bonds (C-O: ~ 351 and CH_x : ~ 413 kJ/mol) and the formation of
6 stronger bonds (C=O: ~ 745 , C=C: ~ 612 and OH: ~ 460 kJ/mol).
7 Samples that have been coated in six passes have a similar thicknesses and roughnesses
8 (S6/350: 1524 nm/338 nm; S6/450: 1483 nm/257 nm; S6/550: 1402 nm/322 nm). This
9 is the reason why the FTIR spectra of these samples show similar peaks and intensities
10 (**Fig. 12**), with a slight difference in the intensity of the broad band that is found around
11 1050 cm^{-1} . However, although some authors have identified a relationship between the
12 area under the SiOSi peak ($\sim 1050 \text{ cm}^{-1}$) and the tribological properties of the coatings
13 [1,10,39], there is no relationship to the 6-pass samples. This is probably due to the
14 harmful effect of the temperature that is reached during the coating process. This effect
15 will be discussed in Section 3.5 *Tribological tests*.

16 It appears that temperature does not affect the samples that were coated in less than six
17 passes, since both the average surface temperature of the samples and their residence
18 times have not been sufficiently high to compromise the quality of the coatings. In fact,
19 ATR-FTIR of 2-pass samples in **Fig. 13** show an increase of the area under the SiOSi
20 peak at the power that is related to lower friction coefficients, as will be detailed in
21 Section 3.5 *Tribological tests*.

22 **3.4 XPS analysis**

23 In regard to the chemical composition, XPS analysis, with an analysis depth of 10 nm
24 [40,41], was used to quantify the atomic composition of the uncoated TPE, activated

1 and coated samples. **Table 3** shows the atomic chemical composition of these samples.
2 Deconvolutions of the Si2p signal of the samples that were coated at 350 and 550 W
3 were undertaken (**Table 4**) to develop a better quantification of the relative percentages
4 of SiO₂, SiO₃ and SiO₄ and its relation to the tribological behavior. **Fig. 14** shows the
5 atomic percentages of C1s, O1s, Si2p and N1s of samples that were coated at 350 W
6 (S6/350, S12/350 and S18/350) and in eighteen passes (S18/350, S18/450 and S18/550),
7 respectively.

8 Related to the activated samples, the chemical composition of the sample activated at
9 550 W (A1/550) and the uncoated TPE are very similar. The same applies to samples
10 activated with 350 W and 450 W. It appears that the surface of samples activated with
11 lower power experiences higher oxidation.

12 In **Table 3** and **Fig. 14**, one can see that, for coated samples, the C1s percentage varies
13 between 51.4% and 60.0%, the O1s percentage varies between 23.3% and 28.7%, the
14 Si2p percentage varies between 11.8% and 16.6% and the N1s percentage between
15 3.3% and 4.2%. These variations do not allow to justify the tribological behavior as it
16 will be discussed in section “3.6 Tribological tests”.

17 However, one can see in **Table 3** the increase in the atomic percentage of Si2p and O1s
18 and the subsequent decrement of C1s percentage of coated samples with respect to the
19 atomic percentages of the uncoated TPE sample. In addition, ATR-FTIR and XPS
20 results of the coated samples showed that the major bond of SiO_x based-films is SiOSi
21 with characteristics peaks at 805 cm⁻¹ and ~1050 cm⁻¹, and the O/Si ratio of the films
22 between 1.7-2.0. The latter is a value that is close to the stoichiometric ratio of silica
23 (O/Si = 2).

1 In regard to the Si2p deconvolutions (see **Table 4**), it is noted that, for a selected
2 number of passes, the SiO₄ percentage increases with the plasma power, indicating a
3 more inorganic character of the coatings.

4 **3.5 Wettability**

5 To investigate the wettability of the samples, water contact angles (WCA) of all
6 samples were measured. It is known that the wettability of a surface is affected by the
7 chemical composition of the first 3 nm surface layer and the surface roughness of the
8 coatings [14,41]. **Fig. 15** illustrates the WCA of the coated samples, uncoated TPE and
9 the polyamide tape. It was not possible to determine the WCA of the flocked seals,
10 since it consisted of polyethylene fibers.

11 On one hand, the WCA of the activated samples (A1/350: $88.4^\circ \pm 3.9$, A1/450: $89.8^\circ \pm$
12 3.1 and A1/550: $93.5^\circ \pm 1.2$) were slightly higher than the uncoated TPE one ($86.0^\circ \pm$
13 6.4) probably due to the higher roughness of these samples after the activation step. On
14 the other hand, for the coated samples, changes in WCA seem to be explained by its
15 differences in roughness together with the inorganic character of the coatings. It was
16 discovered in Section 3.2 *Surface morphology* that the growth mechanisms and the
17 roughness of the coatings depend on the number of passes and the plasma power. In
18 addition to this, the inorganic character of the coatings depends on the SiO₄ (**Table 4**).
19 All coated samples, with the exception of sample S6/550, have a WCA that exceeds that
20 of the polyamide tape ($85.1^\circ \pm 7.4$) and the uncoated TPE ($86.0^\circ \pm 6.4$).

21 3.5.1 Effect of the number of passes

22 For any power, as shown in **Fig. 15**, WCA usually increases with an increase in the
23 number of passes from 2 to 18. These results can often be explained by the roughness
24 values (see **Fig. 3**). Increasing the number of passes from 6 to 18 for a given power

1 increases the roughness and, therefore, the WCA. Similarly, increasing the number of
2 passes from 2 to 6 decreases the roughness and, therefore, the WCA (except for 350W).
3 The wetting behavior of the coatings can be ascribed to the formation of spherical
4 particles that create a roughness. The higher the number of passes is, the greater is the
5 size and the number of particles.

6 In turn, this leads to greater roughness. Therefore, it can be concluded that a rise in
7 WCA is caused by an increase in roughness as other studies have demonstrated [14].

8 3.5.2 Effect of the plasma power

9 Despite the high standard deviation (SD) of WCA (see **Fig. 15**), it seems that an
10 increase in plasma power from 350 to 550 W results in a lower WCA, for samples that
11 have been coated in 6, 12 or 18 passes. This is in agreement with the increasing
12 inorganic character of the samples with higher power as one can see in **Table 4**.

13 In previous works of this research group, WCAs were related to the roughness of the
14 coatings [2]. However, in this work, although a decrease of the roughness with the
15 power could be observed in **Fig. 3**, the variations are not so significant as to ensure that
16 such relation is complied.

17 WCAs of samples that have been coated in two passes are practically the same ($\sim 87^\circ$)
18 and are very similar to the uncoated TPE WCA ($86.0^\circ \pm 6.4$). It seems that the use of
19 two passes generates an incomplete coverage of the substrate. Thus, there is a minimum
20 number of passes necessary for full-coverage the substrate surface [42].

21 For samples whose roughness is similar to that of uncoated TPE (RMS: 364 ± 32 nm),
22 differences in WCAs are explained by their chemical composition, since after
23 deposition of an APTES-based coating, the wettability of the sample increased in
24 agreement with the presence of SiO_x groups that are characteristics of the APTES
25 molecule. As an example, sample S6/350, whose RMS is 338 nm, has a WCA that is

1 considerably greater than that of the uncoated TPE (S6/350: $102.0^\circ \pm 6.6$ and uncoated
2 TPE: $86.0^\circ \pm 6.35$), since the uppermost layer of this sample consists of SiO_x, with an
3 O/Si ratio of 1.9, which is close to the stoichiometric ratio of silica (O/Si = 2).
4 Furthermore, the cracks observed in SEM images likely result from the evolution of the
5 coating to a silica structure [4].

6 **3.6 Tribological tests**

7 The coefficients of friction (CoF) of samples that were coated at 350 and 550 W
8 together with the uncoated TPE sample and the current industrial solutions (flocked
9 seals and polyamide tape) appear in **Fig. 16**, **Fig. 17** and **Table 5** show the average
10 friction coefficient of the coated samples and the uncoated TPE.

11 A friction test with a sliding distance of 4000 m was selected to reproduce the rigors of
12 the operation that the coating on a seal of a vehicle undergoes during its lifetime. This
13 distance is much longer than that used in previous work [1,10,30]. In the beginning of
14 this paper, it was mentioned that one of the main goals was to obtain coatings that could
15 replace the solutions that are used in automotive sealing today (flocked seals and
16 polyamide tape), especially to eliminate the slippage between the window channels and
17 the glass. Therefore, a coating with lower friction coefficient and the same or greater
18 durability than these technical solutions is necessary. The average friction coefficient of
19 a flocked seal is 0.25 ± 0.06 , whereas that of a polyamide tape is 0.28 ± 0.01 . The
20 friction coefficient of the activated samples was similar to the uncoated TPE one
21 (0.68 ± 0.02).

22 **Fig. 16** shows that the friction coefficient of the flocked seal gradually increases to 3000
23 m, reaching a steady state with a friction coefficient of ~ 0.3 . The friction coefficient of
24 the polyamide tape is practically constant during the 4000 m of sliding distance. Finally,

1 it is noted that the friction coefficient of all of the coated samples is lower than that of
2 the uncoated TPE. As previously stated, when temperature-sensitive substrates are used,
3 both the surface temperature of the samples and its residence time have a significant
4 influence on the tribological behavior of the coated samples. As has been mentioned,
5 the higher the plasma power and number of passes are, the higher is the average surface
6 temperature (see **Fig. 1**). Several authors have reported that, when the thermal
7 expansion coefficients of substrate and coatings differ, residual thermal stress is
8 generated [43–45]. The higher the process temperature (depending on plasma power and
9 number of passes), the higher is the residual thermal stress of the coating. In addition, it
10 is worth noting that the increase in residual thermal stress with coating depth reaches a
11 maximum value in the bond area coating-substrate. The coatings under consideration
12 are subjected to a thermal tensile stress, since the thermal expansion coefficient of TPE
13 substrate is higher than that of the coatings. As confirmed [46], coatings that are
14 subjected to high thermal tensile stress have a poorer friction behavior.

15 3.6.1 Effect of the number of passes

16 **Fig. 16, Fig. 17** and **Table 5** indicate that samples S6/350, S12/350 and S18/350 have
17 the lowest friction coefficients of all analyzed samples, including the current industrial
18 solutions (flock and polyamide tape). In addition, these friction coefficients decline
19 slightly with a decrease in the number of passes (CoF S6/350 < S12/350 < S18/350).
20 The best sample is S6/350 probably because this sample has been subjected to lower
21 process time. This produces a lower average surface temperature (see **Fig. 1**), less
22 residual thermal stress and a better friction performance. Otherwise, sample S2/350 has
23 a friction coefficient that exceeds the remaining samples that were coated at 350 W and
24 the current industrial solutions, probably because its surface is not fully coated (see **Fig.**

1 **4** and **Fig. 5[a]**). Therefore, it seems that a minimum coating thickness is necessary to
2 enhance a friction coefficient that is lower than those of the current industrial solutions.
3 Samples that have been coated at 550 W have friction coefficients that exceed those of
4 the current industrial solutions (see **Fig. 16** and **Fig. 17**). As can be seen in **Fig. 16** and
5 **Table 5**, sample S2/550 has a friction coefficient that is nearly constant and is the
6 lowest of the 550 W-samples. A comparison of the friction coefficient of samples
7 S2/550 and S6/550 in **Fig. 16** shows that sample S6/550 has a lower friction coefficient
8 than sample S2/550 during the first 2000 m of the test. This could be because the
9 surface of this sample (S2/550) is not full-coverage. This would cause its friction
10 coefficient to depend not only on the coating, but also on the TPE substrate. In contrast,
11 the surface of sample S6/550 is full-coverage with a 1402 nm thickness coating. In
12 addition, the coating of sample S6/550, although worn, has not reached a point at which
13 it is subject to high residual thermal stress that could compromise the friction behavior,
14 despite having been subjected to a high temperature (108.0 °C) for a longer time (224 s).
15 From the 2000 m of sliding distance to the end of the test, sample S2/550 had a lower
16 friction coefficient than S6/550, probably because its surface was subjected to a high
17 temperature (101.1 °C) for only a short time (75 s). Thus, the anti-friction ability was
18 not significantly affected by the residual thermal stress of this sample.

19 In **Fig. 16**, the friction coefficient of sample S6/550 shows three different behaviors.
20 During the first stage (0-1000 m), the friction coefficient began at ~0.12 and increased
21 linearly to ~0.19, since the first nanometers of the coating are not subjected to residual
22 thermal stress that could worsen the anti-friction property. In the second stage (1000-
23 2000 m), the friction coefficient fluctuated. This was probably due to successive cycles
24 of the coating breaking and developing tribofilm. That is, after a sliding distance of
25 1000 m, the steel ball reached depths of coating at which the residual thermal stress

1 leads to coating detachment. During this process, an increase in the friction coefficient
2 could be observed. Then, a tribofilm of detached material was formed that rubbed
3 against the steel ball. This led to a decrease in the friction coefficient, since the tribofilm
4 acts as a lubricant. When the tribofilm is completely worn, the steel ball may rub against
5 the original coating and this cycle will repeat. Finally, in the third stage (2000–4000 m),
6 there is a sharp increase in the friction coefficient. In this situation, the residual thermal
7 stress is high enough to cause complete detachment of the coating so that tribofilm
8 cannot be formed. The TPE surface is exposed to the steel and so the friction coefficient
9 value is similar to that of the TPE.

10 Friction coefficients of samples S12/550 and S18/550 were similar during the entire
11 test. Both samples were subjected to the highest temperatures for the longest time
12 (113.1 °C for 449 s and 116.3 °C for 673 s respectively). This caused the highest
13 residual thermal stress in these coatings. In **Fig. 16**, one can see two different stages
14 during the friction test of these two samples. The first stage (0-600 m) is similar to the
15 first stage that was identified for sample S6/550. The value of the friction coefficient
16 started at ~0.23 and linearly increased to ~0.27. In the second stage (600-4000 m), there
17 was a greater fluctuation of the friction coefficient due to successive cycles of the
18 coating breaking. A development of tribofilm was observed that was comparable to that
19 of the S6/550 sample. This behavior was maintained until the end of the test. However,
20 if the sliding distance of the test was longer, it is estimated that a complete detachment
21 of the coating would have occurred and the friction coefficient would have increased to
22 a value close to that of the TPE that sample S6/550 experienced in its third stage.

23 In order to examine the quality of the coating at the end of the friction test, **Fig. 18**
24 shows SEM wear track images and EDX analyses of sample S18/550 after a friction test
25 of 4000 m.

1 In the EDX maps, the red color corresponds to carbon, the blue color represents the
2 silicon and the yellow color is associated with oxygen. One can see in **Fig. 18[a] and**
3 **[c]** different numbered regions of the coating. Region 1 corresponds to an undamaged
4 coating area of spherical particles of SiO_x . The latter are similar to the particles of **Fig.**
5 **4[f]**, since this area has not been in contact with the steel ball during the friction test. In
6 fact, its EDX map (**Fig. 18 [c]**) evinces a uniformly green coating of SiO_x that was
7 derived from the mixture of silicon (blue) and oxygen (yellow). Region 2 depicts a
8 transition area. This region is shown as a brittle coating where the detected cracks of
9 Region 1 have become wider and the spherical particulates of the surface have been
10 eroded. Region 3, together with **Fig. 18[b] and [d]**, represents the central area of the
11 wear track, in which flattened areas of SiO_x (green) of the remaining coating and
12 tribofilm appear. The wear in this region caused the coating to detach, which resulted in
13 areas where the TPE substrate can be observed (red color of carbon). These images
14 show debris of the coating (white circles in **Fig. 17[c] and [d]**) from which the tribofilm
15 is created. These flattened areas of SiO_x at the end of the friction test ensure that the
16 value of the friction coefficient is 50% less than that of the uncoated TPE.

17 3.6.2 Effect of plasma power

18 **Fig. 17** and **Table 5** indicate that, for samples that were coated in 6, 12 or 18 passes, the
19 higher the power was, the higher the friction coefficient was for a selected number of
20 passes. This could be related to the more energetic plasma and the subsequent high
21 temperature to which both the coating and the TPE substrate were subjected during the
22 deposition process. These could result in an increase in the residual thermal stress of the
23 sample after cooling to room temperature (21 °C). As was discussed earlier, residual
24 thermal stress has a negative impact on the friction behavior of the samples.

1 However, the opposite result was found with 2-pass samples. Higher power led to lower
2 friction coefficients. These samples were subjected to different average surface
3 temperatures for the shortest residence times (75 s). This produced lower residual
4 thermal stress than for other samples that were coated in a higher number of passes. In
5 such a situation, the friction behavior seems to depend on the chemical composition of
6 the coatings as was demonstrated by other authors [1,2,10]. In this regard, the sample
7 that was coated at 550 W (S2/550) had the highest absorption area under the SiOSi peak
8 in the ATR-FTIR spectrum (see **Fig. 13**) and the highest SiO₄ percentage (7.0%) after
9 the Si2p deconvolution in XPS analyses (see **Table 4**). This provided a friction
10 coefficient that was less than those of the samples that were coated at a lower power
11 (S2/350 and S2/450).

12 **4 Conclusion**

13 Plasma polymerized films of APTES over TPE substrates were prepared successfully by
14 use of an APPJ system to obtain a higher WCA and lower friction coefficient than those
15 of the current industrial solutions (flocked seals and polyamide tape). The key findings
16 of this research are the following:

- 17 • It was discovered that the growth mechanisms depend on the plasma power and the
18 number of passes, as determined by the RMS measurements and SEM and AFM
19 images.
- 20 • Two key variables that determine the friction performance of the samples are: [a]
21 the average surface temperature of the samples during the coating process
22 (depending on the plasma power and the number of passes) and [b] the coating
23 thickness. If the average surface temperature exceeds a certain value, the residual
24 thermal stress could compromise the anti-friction ability. However, it is necessary
25 that the substrate surface be covered entirely.

- 1 • Successful samples (those with a friction coefficient that is less than the current
2 industrial solutions) were samples that were coated in 6, 12 or 18 passes and a
3 plasma power of 350 W or coated in six passes and a plasma power of 450 W. The
4 average surface temperature of all of these samples during the coating process did
5 not exceed 92 °C, and the thickness of the coatings was greater than 1000 nm.
- 6 • Samples that were coated in six passes and at a power of 350 W proved to have the
7 best friction performance. This sample had a friction coefficient 46% and 53%
8 lower than that of the flocked seals and polyamide tape respectively.
- 9 • The wettability of the coated samples depends mainly on the roughness, as no
10 significant chemical variations in the uppermost layer (3 nm) were identified.
- 11 • All the studied samples, except the S6/550 sample, had a WCA that was higher
12 than that of the polyamide tape ($85.1^\circ \pm 7.4$) and the uncoated TPE ($86.0^\circ \pm 6.35$).
13 Sample S18/350 had the highest WCA ($116.5^\circ \pm 7.0$). It was 37% higher than the
14 WCA of the polyamide tape.

15 In future research, the authors will undertake the following:

- 16 • Establish the plasma polymerization parameters that provide anti-friction properties
17 that are similar to those of the current industrial solutions, but are less costly. That
18 is, it is not necessary that coatings have friction coefficients as low as discussed in
19 this paper. For instance, the minimum number of passes, with a plasma power of
20 350 W that is required to obtain a similar friction performance to that of the current
21 industrial solutions will be studied. The intention will be to reduce the costs related
22 to the plasma equipment, plasma gas consumption and other consumables in a
23 future industrial process.

- 1 • Finally, in order to standardize this technology in the automotive industry, other
2 tests related to ozone stability, solar radiation, etc., will be implemented.

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Table 1

Sample	Power (W) (activation and polymerization)	Number of passes (activation)	Number of passes (polymerization)	Deposition time (s) (polymerization)	Average Surface Temperature (°C)
A1/350	350W	1	-	-	68.3
S2/350		1	2	75	70.0
S6/350		1	6	224	75.3
S12/350		1	12	449	79.5
S18/350		1	18	673	82.4
A1/450	450W	1	-	-	81.7
S2/450		1	2	75	83.8
S6/450		1	6	224	90.5
S12/450		1	12	449	94.6
S18/450		1	18	673	97.6
A1/550	550W	1	-	-	98.0
S2/550		1	2	75	101.1
S6/550		1	6	224	108.0
S12/550		1	12	449	113.1
S18/550		1	18	673	116.3

Table 1. Sample identification and deposition conditions of each sample.

Table 2

Sample	Thickness (nm)	Standard deviation (SD)	Roughness (nm)	Standard deviation (SD)
A1/350	-	-	405	13
S2/350	230	47	401	31
S6/350	1524	559	338	45
S12/350	2123	503	461	37
S18/350	2938	854	724	48
A1/450	-	-	406	22
S2/450	190	19	276	22
S6/450	1483	413	257	25
S12/450	2563	448	413	35
S18/450	2871	754	636	51
A1/550	-	-	389	19
S2/550	160	32	376	28
S6/550	1402	407	322	30
S12/550	2475	398	376	29
S18/550	2880	863	629	49
Uncoated TPE	-	-	364	32

Table 2. Thickness and roughness of all the analyzed samples.

Table 3

Sample	Atomic chemical composition (at. %)			
	C1s	O1s	Si2p	N1s
A1/350	81.0	15.2	3.0	0.8
S2/350	64.2	20.7	11.7	3.4
S6/350	55.3	26.5	14.1	4.2
S12/350	58.0	24.9	13.7	3.4
S18/350	56.7	25.2	14.1	4.1
A1/450	82.5	14.4	1.7	1.4
S2/450	60.9	23.6	12.0	3.5
S6/450	58.3	24.8	13.3	3.7
S12/450	58.2	24.8	13.6	3.4
S18/450	53.1	28.1	14.8	4.0
A1/550	93.0	6.2	0.7	0.1
S2/550	58.4	24.1	14.4	3.2
S6/550	54.0	27.6	15.1	3.3
S12/550	58.3	25.0	13.4	3.4
S18/550	51.4	28.7	16.6	3.3
Uncoated TPE	94.3	4.5	1.2	-

Table 3. Atomic chemical composition (at. %) of all the analyzed samples.

Sample	Relative percentage (%)		
	SiO ₂ (~102.1 eV)	SiO ₃ (~102.8 eV)	SiO ₄ (~103.4 eV)
S2/350	-	7.9	3.8
S2/550	-	7.4	7.0
S6/350	2.0	5.0	7.0
S6/550	0.0	5.2	10.0
S12/350	2.0	6.2	5.5
S12/550	1.8	5.8	7.6
S18/350	3.6	3.9	6.6
S18/550	0.0	7.3	9.3

Table 4. Relative percentage (%) of SiO₂, SiO₃ and SiO₄ of samples coated at 350W and 550W.

Table 5

Sample	Average friction coefficient
S2/350	0.43 ± 0.03
S6/350	0.13 ± 0.02
S12/350	0.14 ± 0.01
S18/350	0.17 ± 0.01
S2/450	0.39 ± 0.04
S6/450	0.24 ± 0.02
S12/450	0.25 ± 0.10
S18/450	0.35 ± 0.19
S2/550	0.39 ± 0.02
S6/550	0.41 ± 0.20
S12/550	0.44 ± 0.05
S18/550	0.36 ± 0.06
Uncoated TPE	0.68 ± 0.02
Flocked seal	0.25 ± 0.06
Polyamide tape	0.28 ± 0.01

Table 5. Average friction coefficient of all of the coated samples, the uncoated TPE, flocked seal and the polyamide tape.

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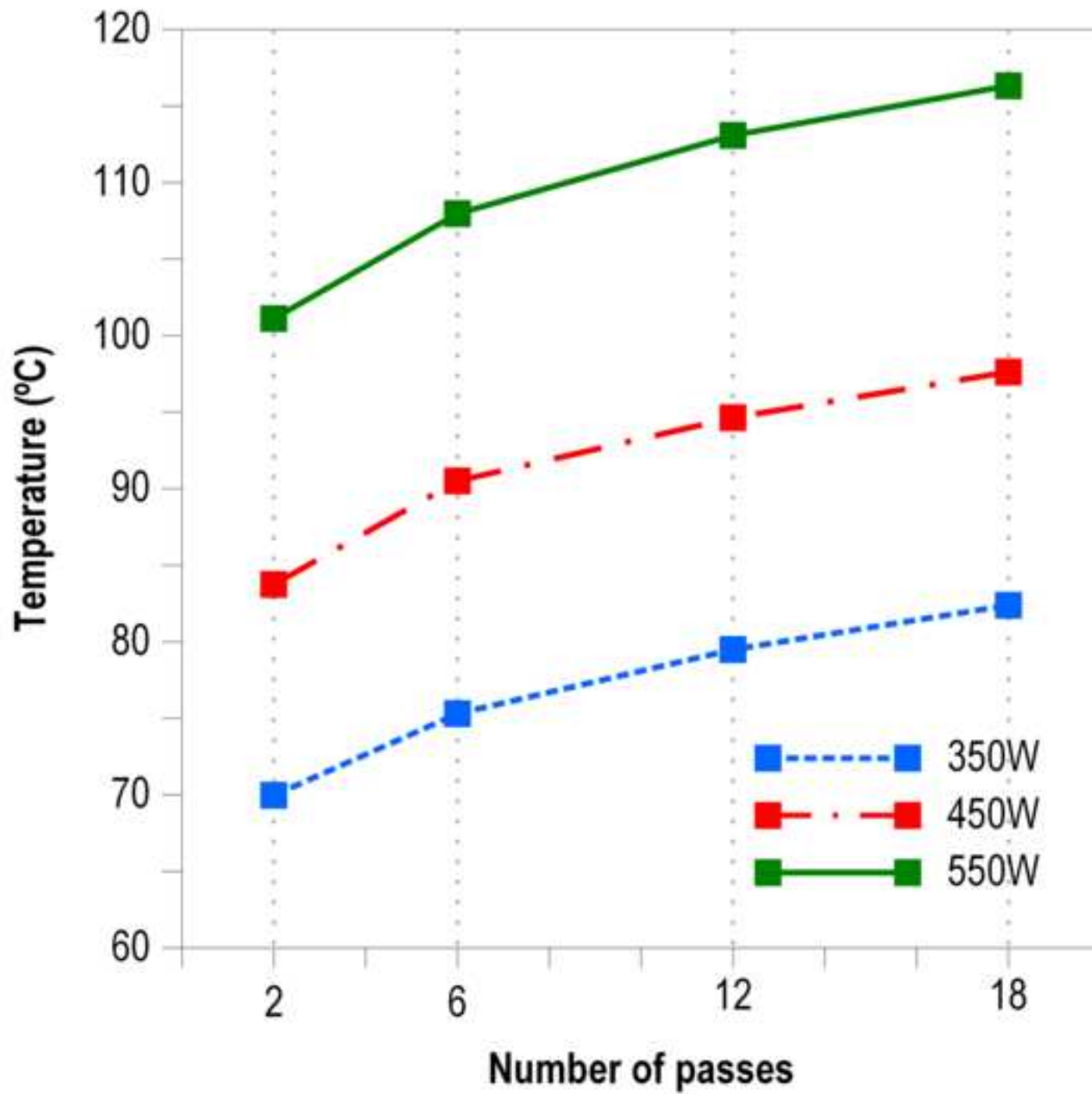


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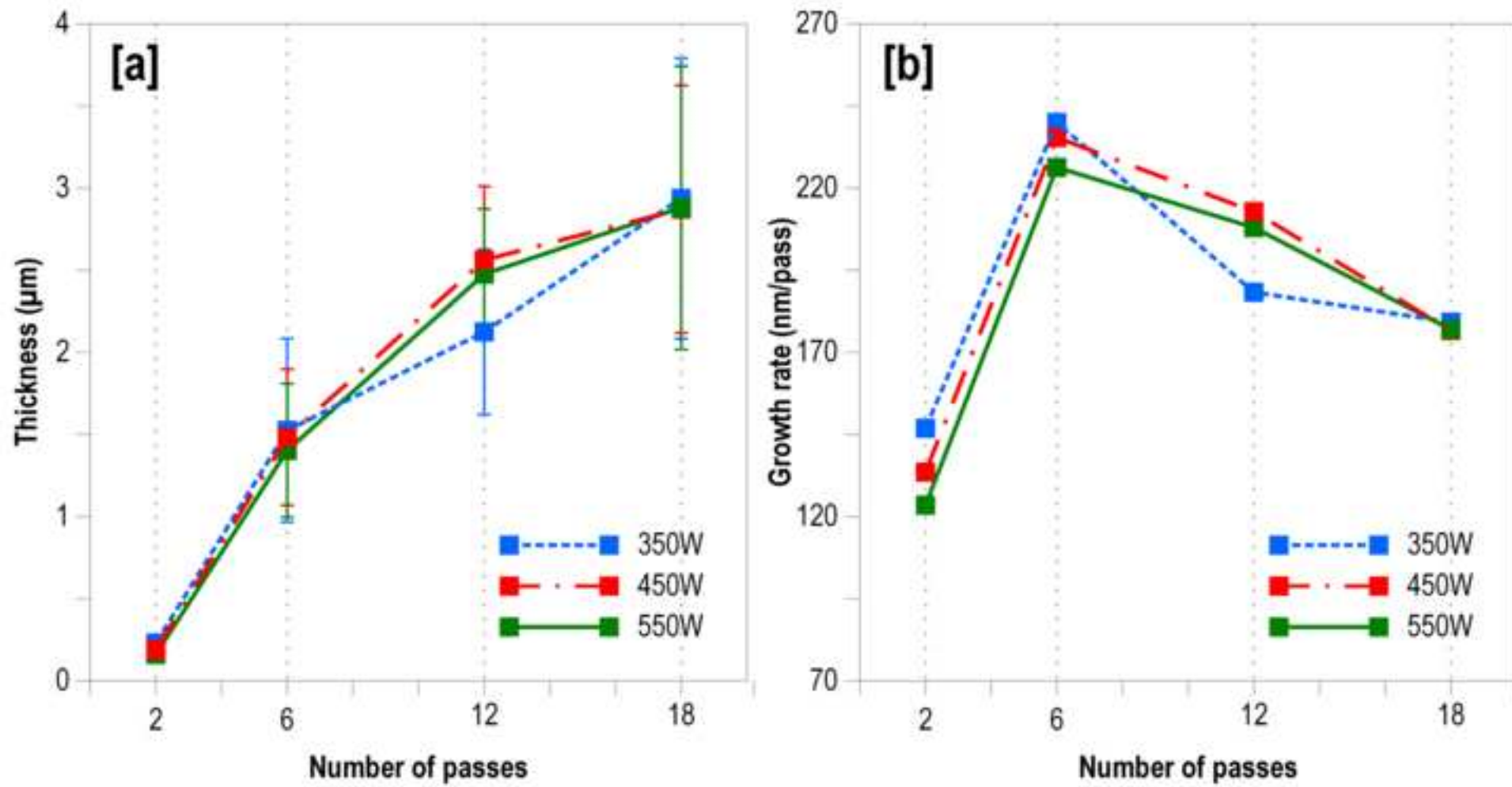


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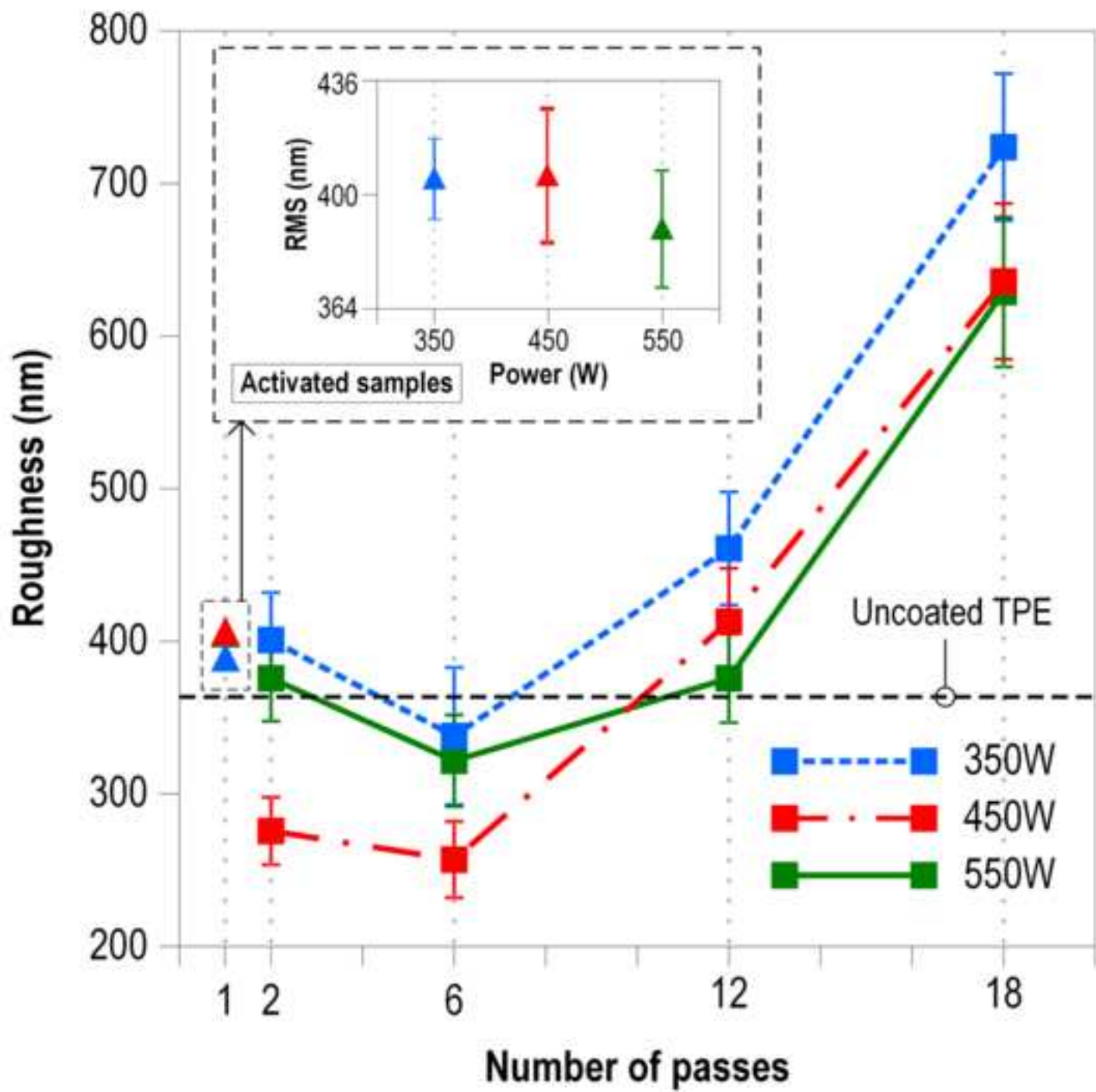


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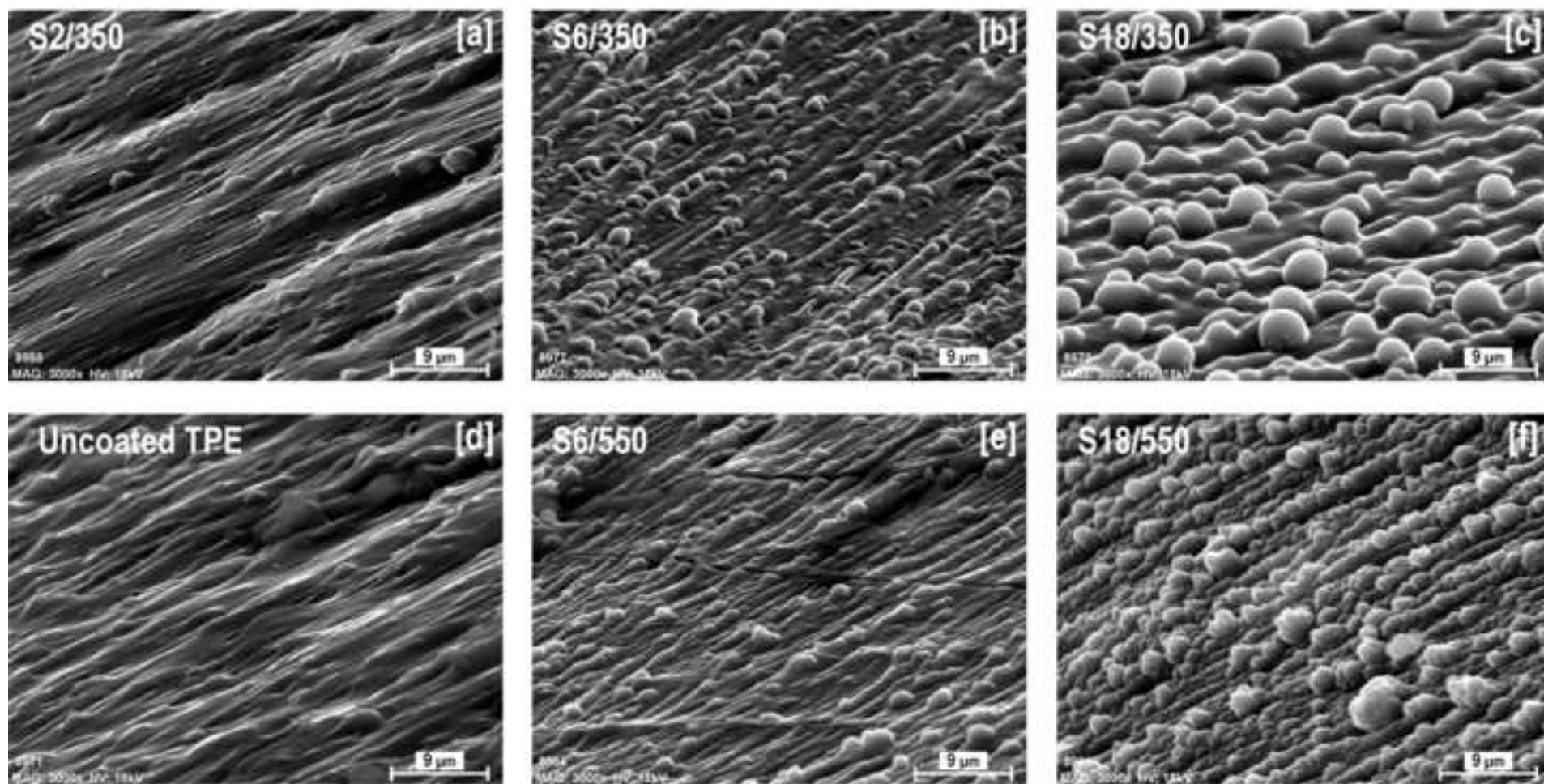


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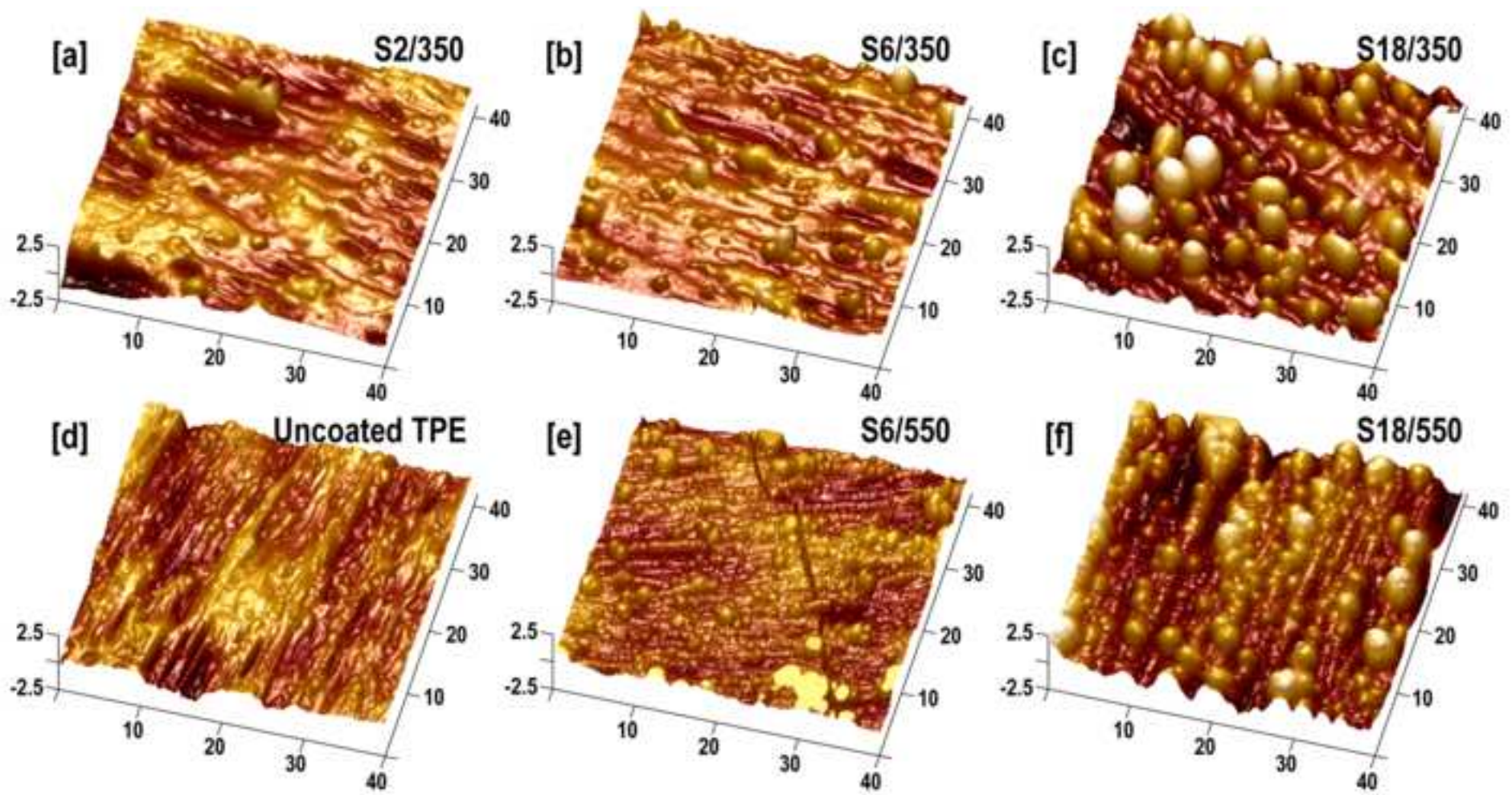


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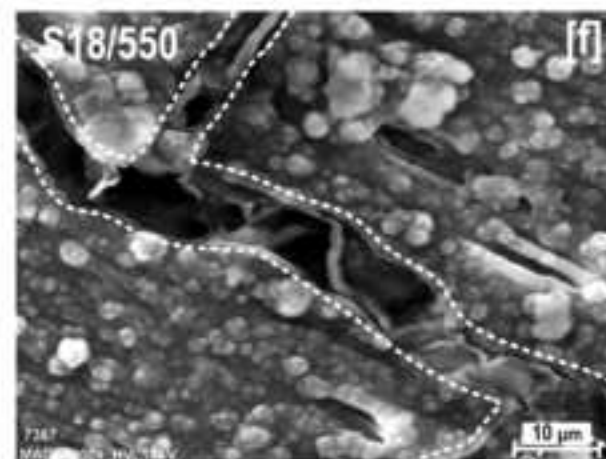
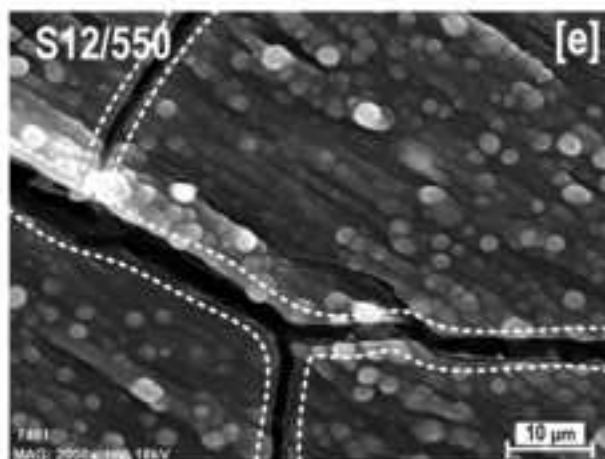
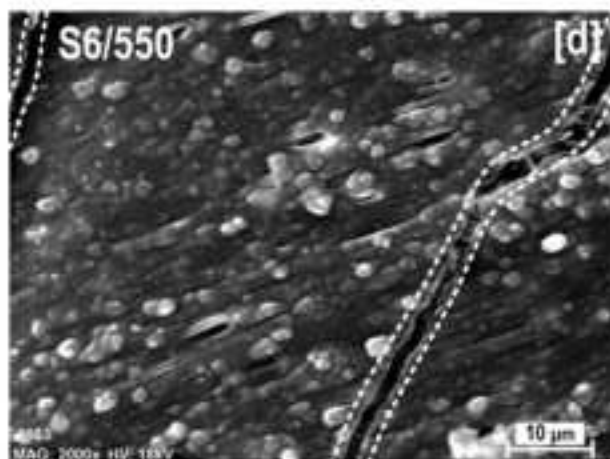
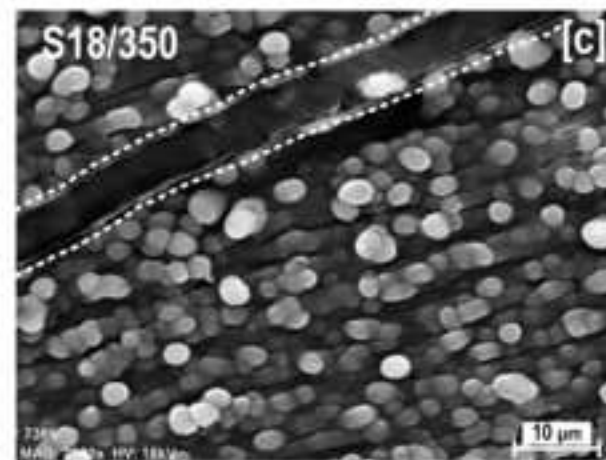
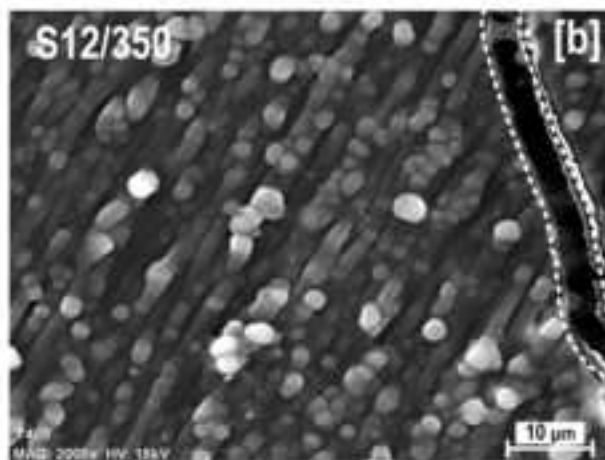
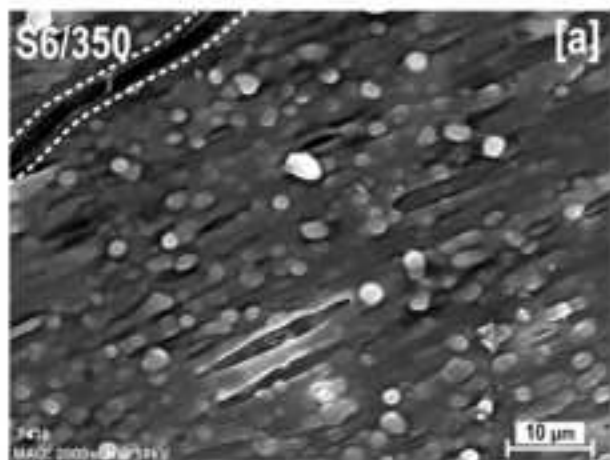


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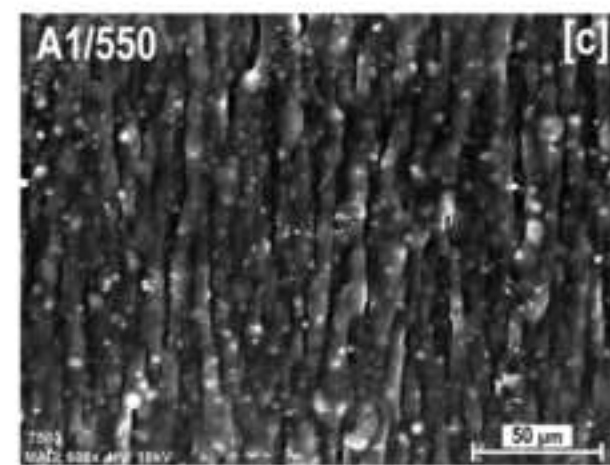
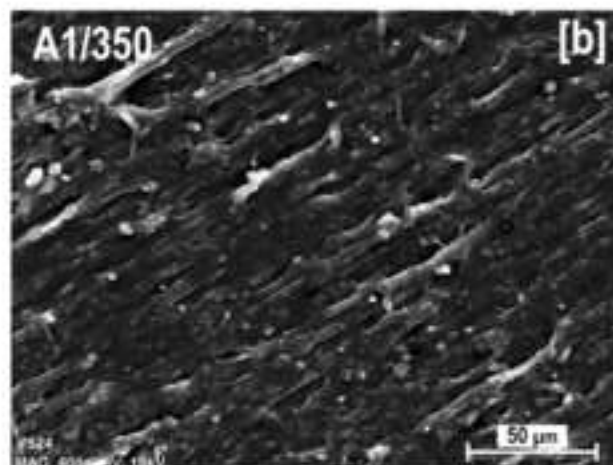
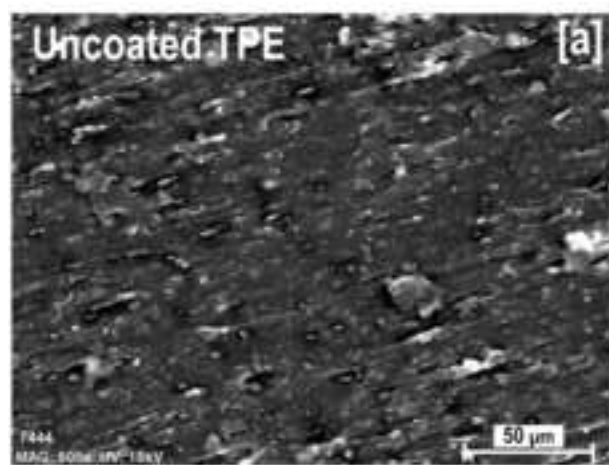


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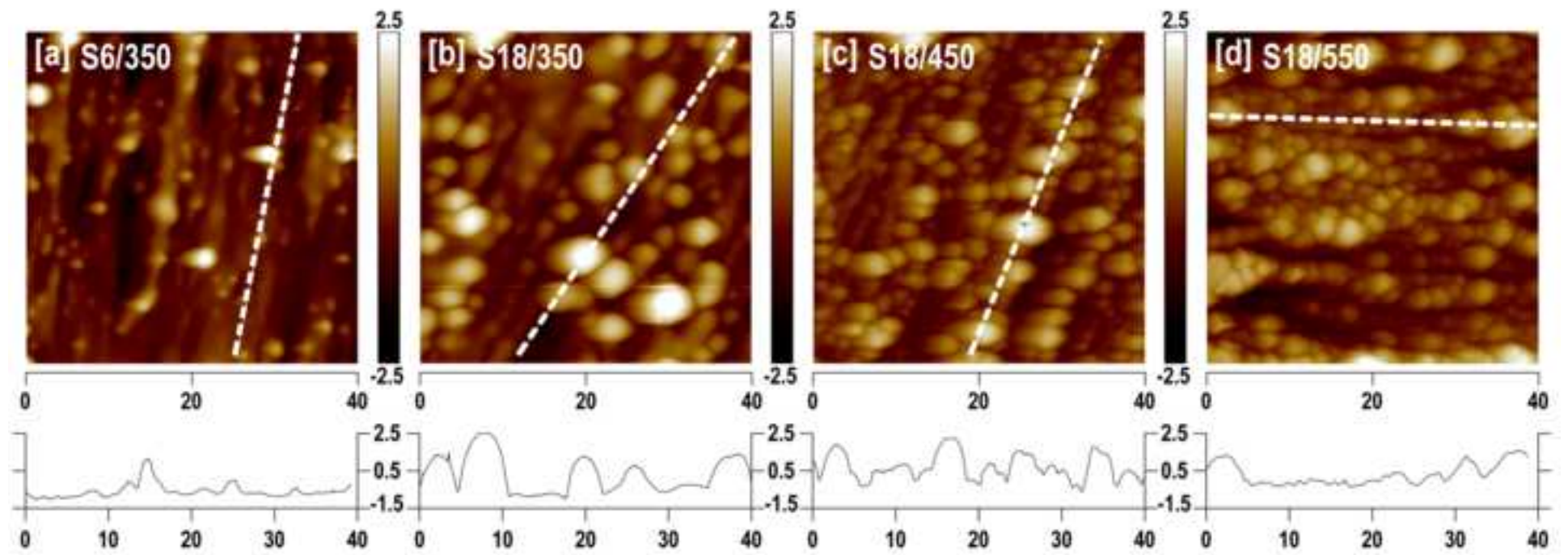


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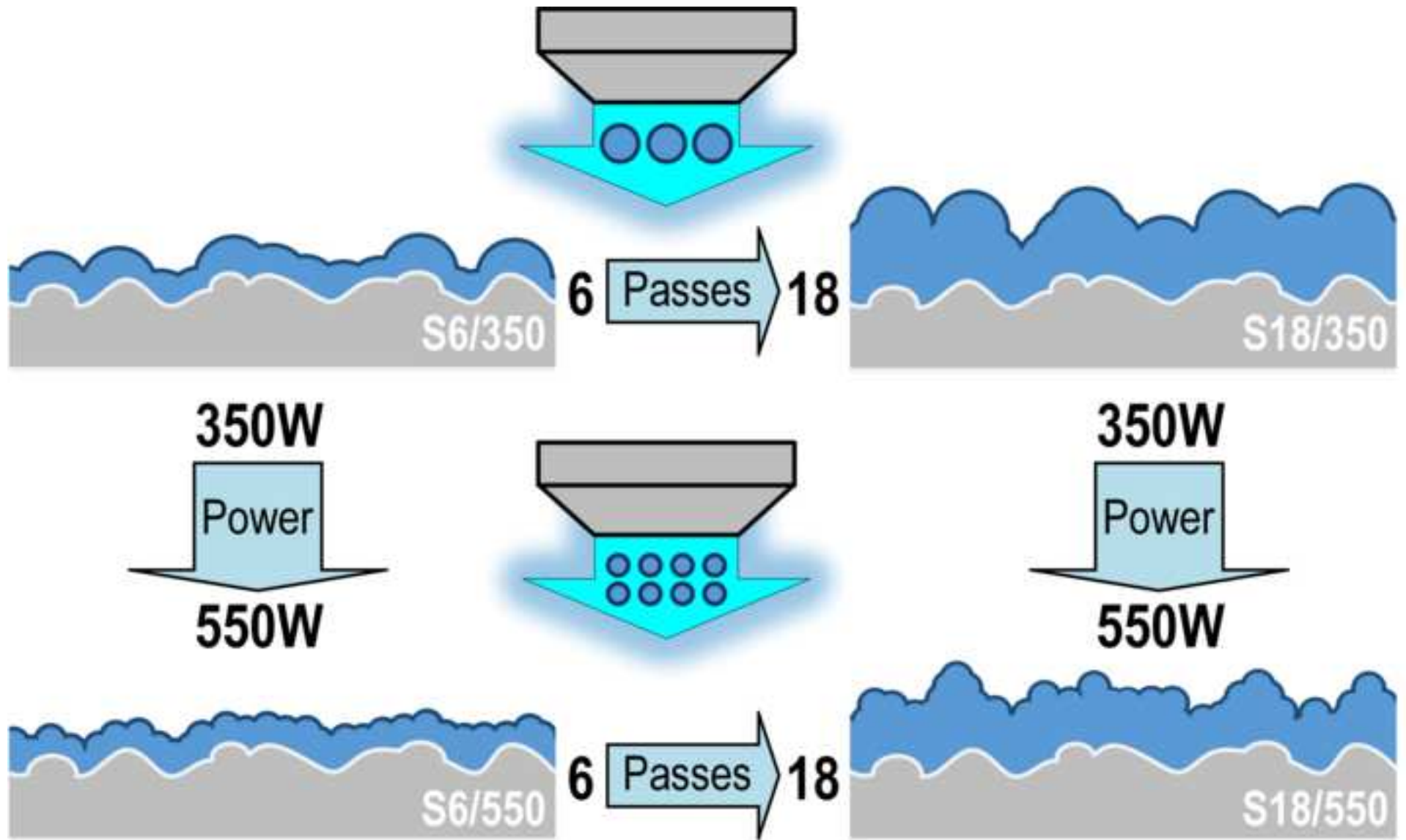


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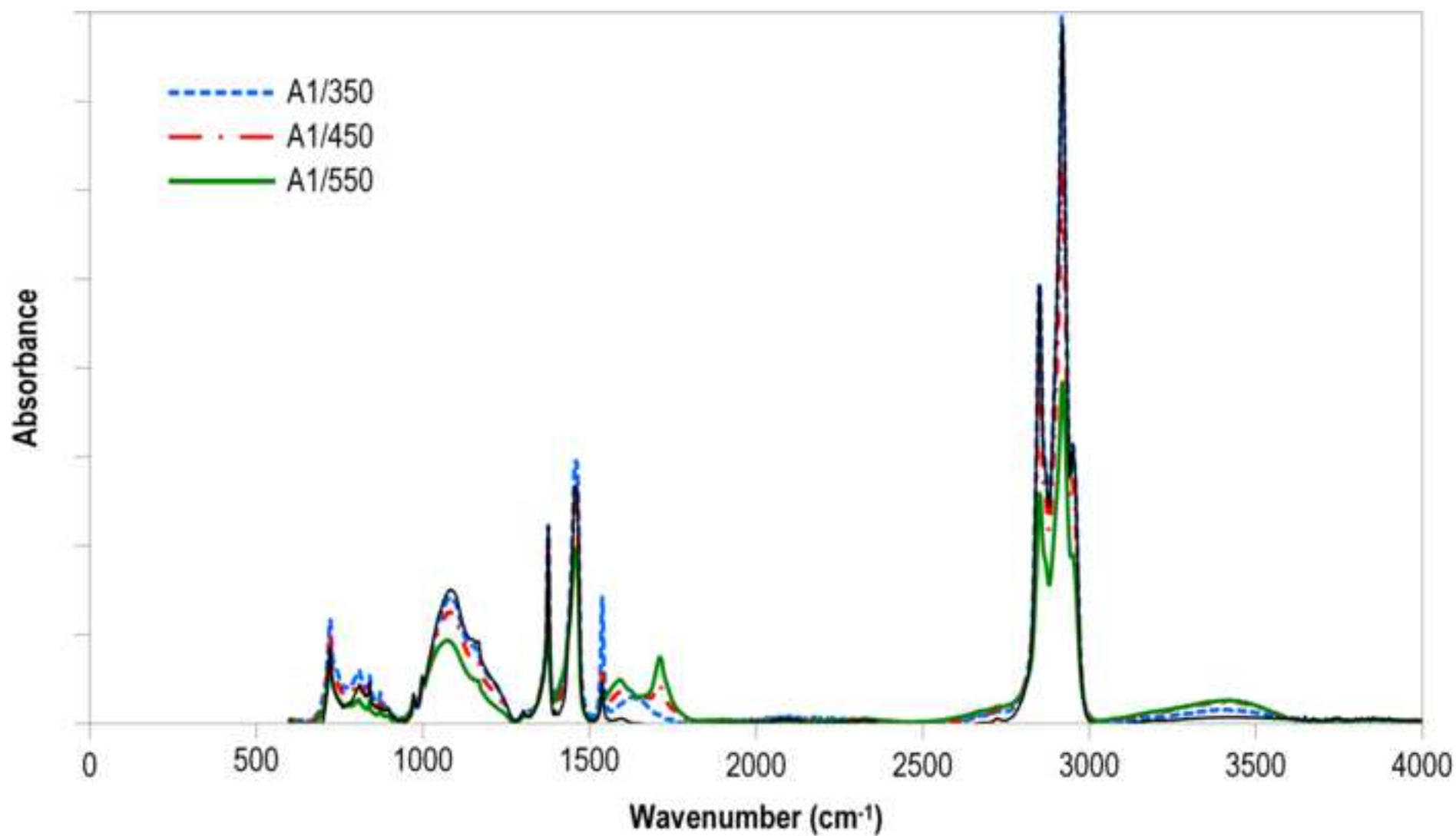


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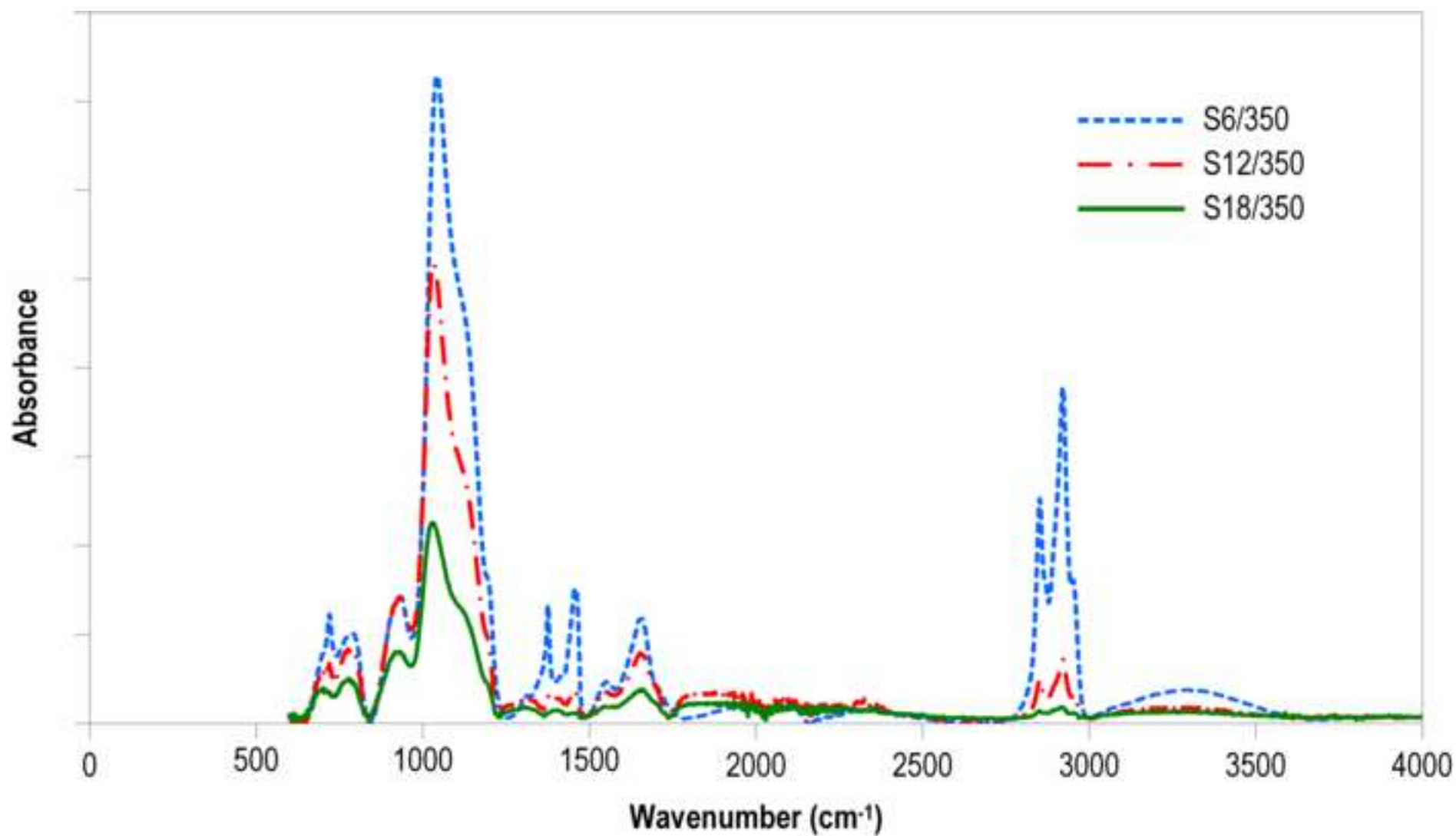


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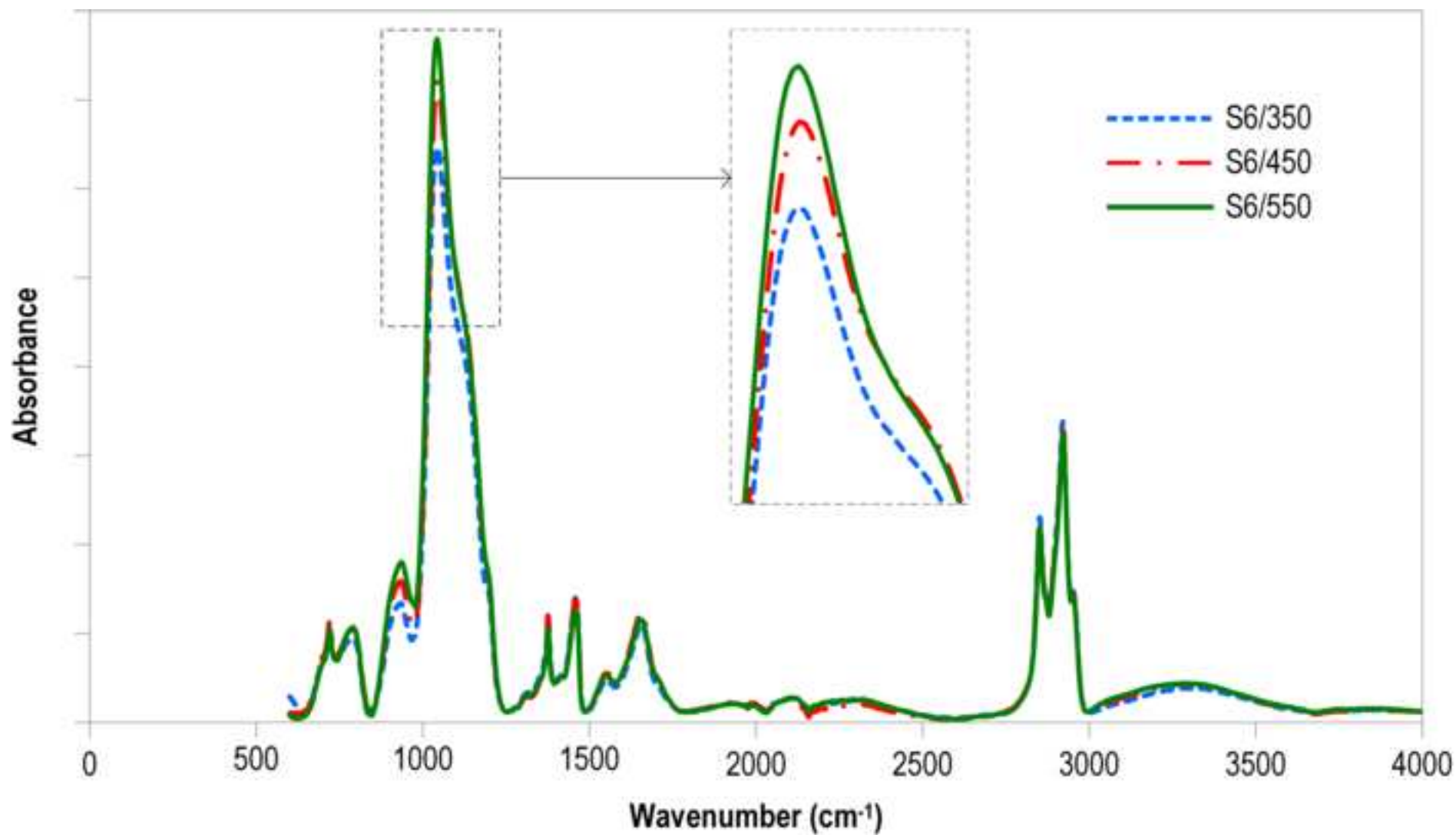


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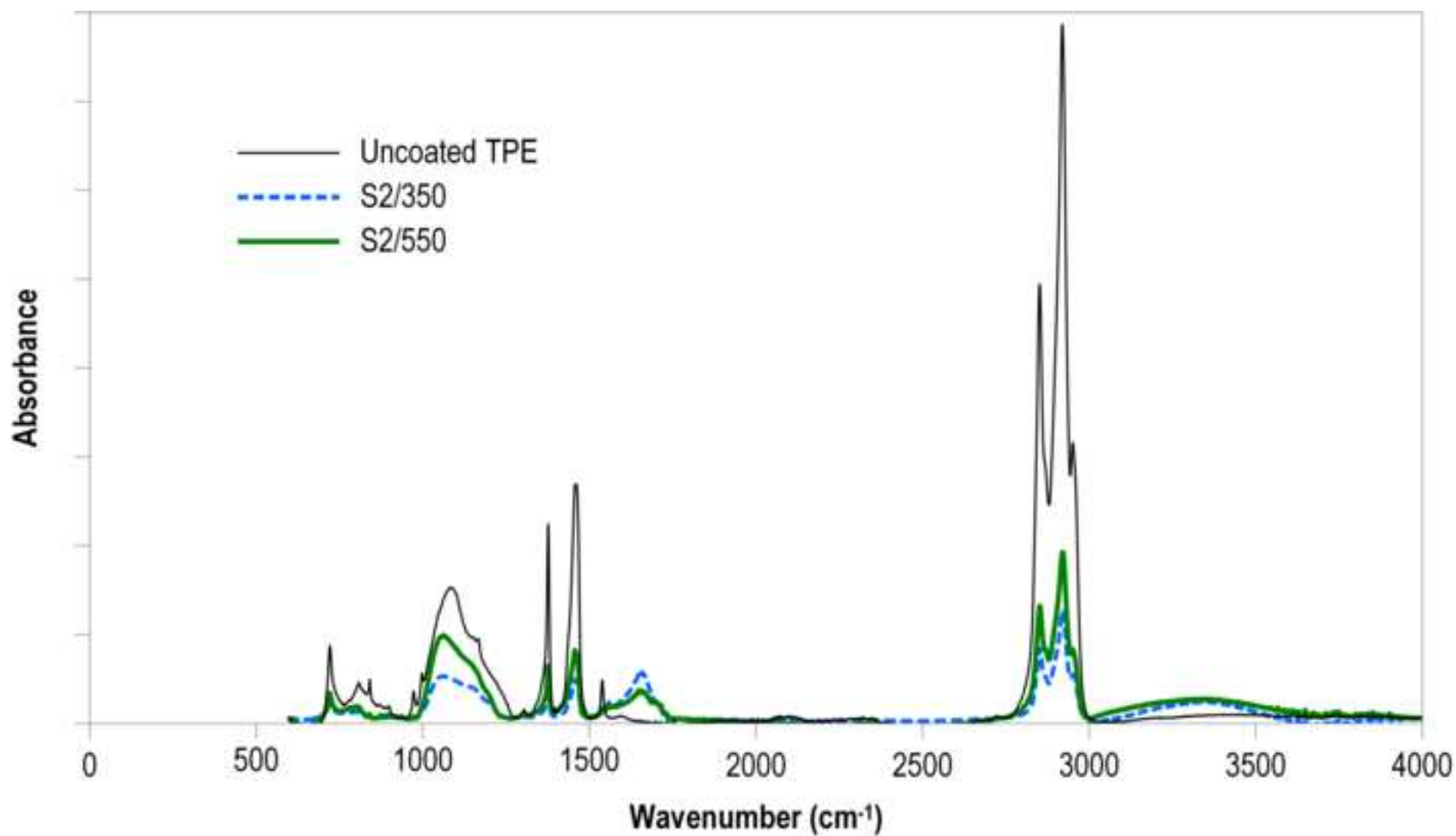


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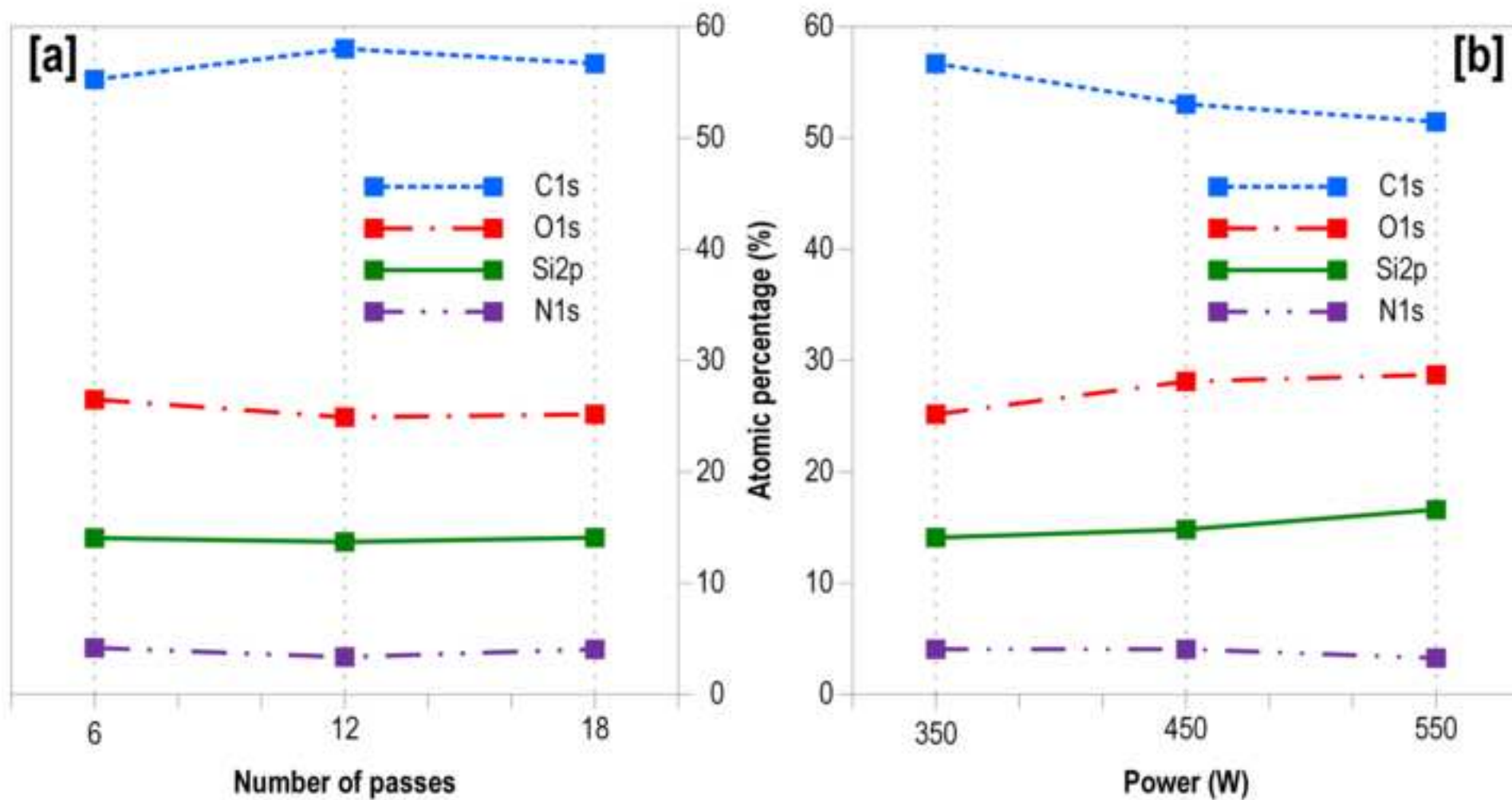


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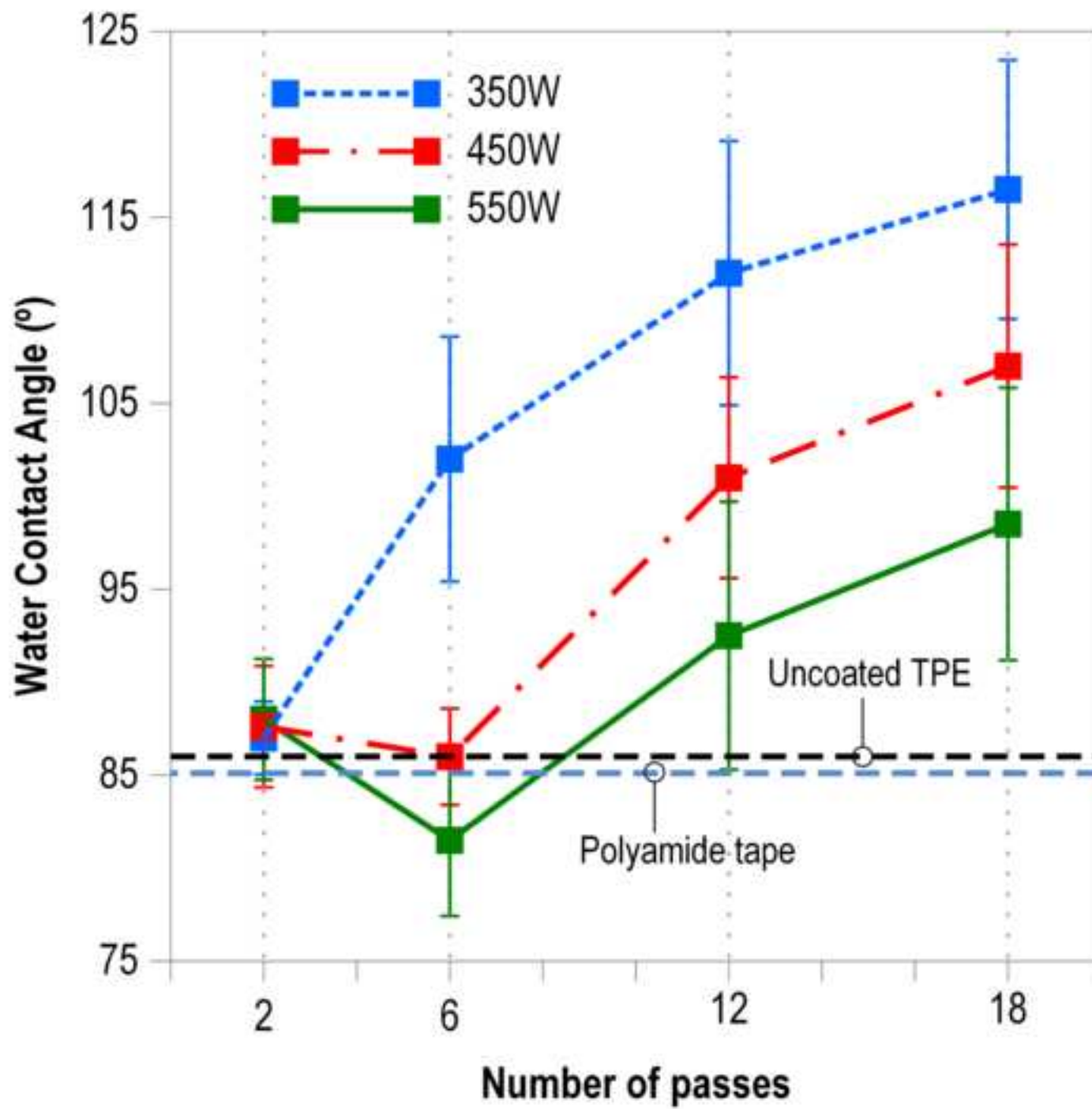


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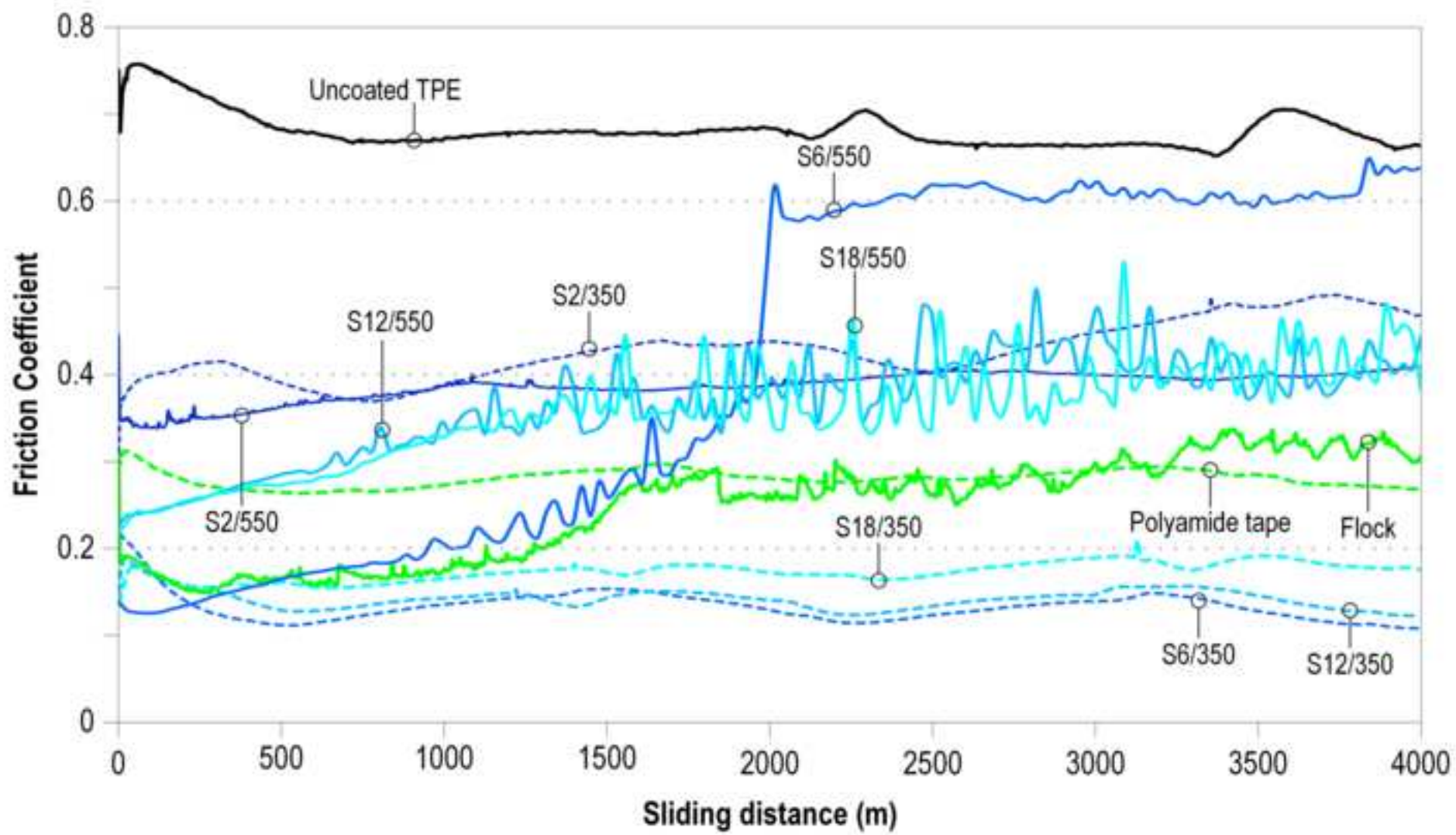


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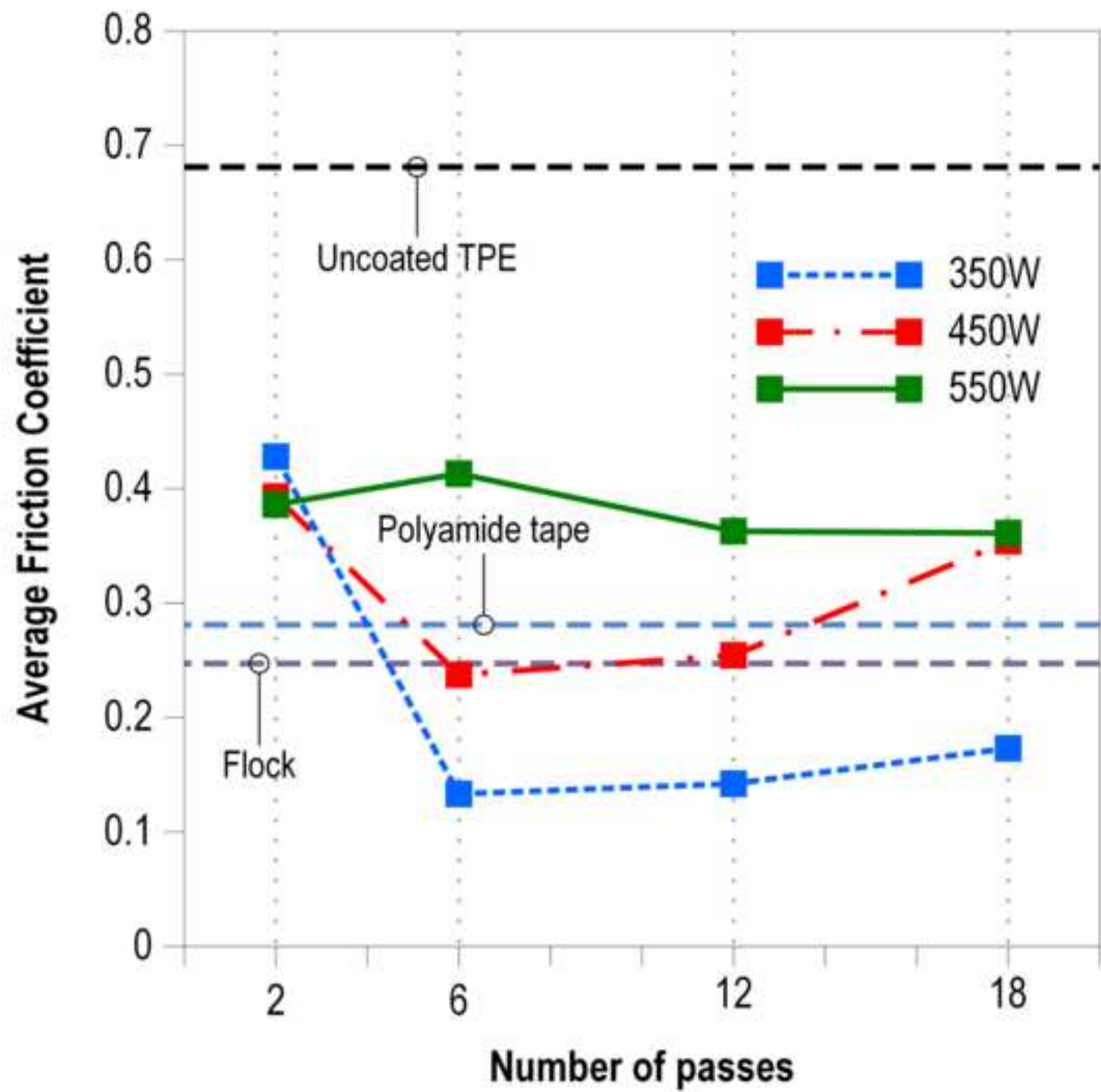


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